

# **Specular BSDF Measurement Capability at NASA GSFC using a Table-Top Goniometer in Support of the Calibration of Remote Sensing Instruments**

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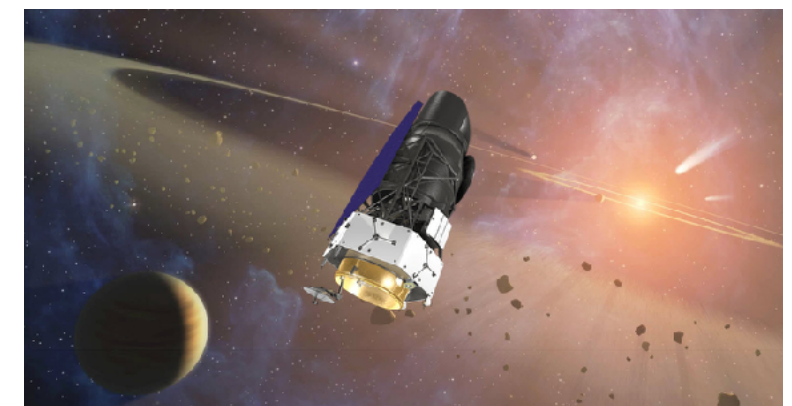
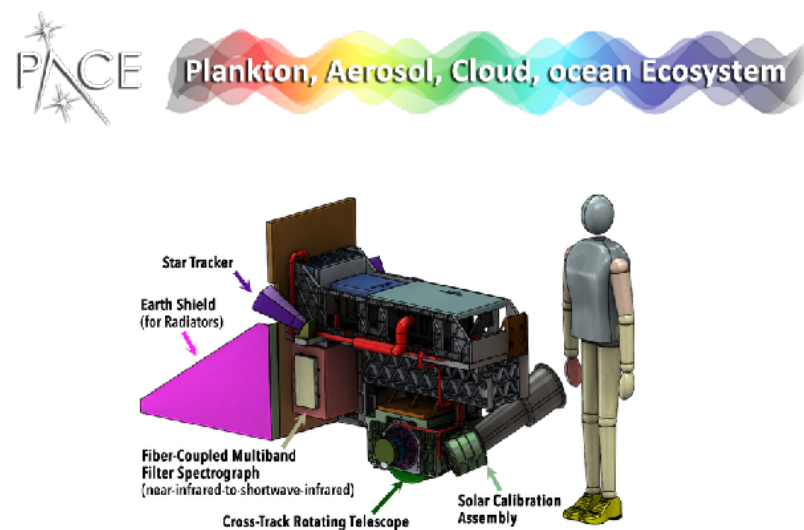
**<sup>2</sup>NASA Goddard Space Flight Center, Greenbelt, MD, 20771 USA**

**CALCON 2019  
Logan, UT**

# Motivation

**New BSDF measurement capability for specular/polished surface using TTG (Laser-based goniometer, large dynamic range, low instrument signature, flexibility to accommodate different optical surfaces)**

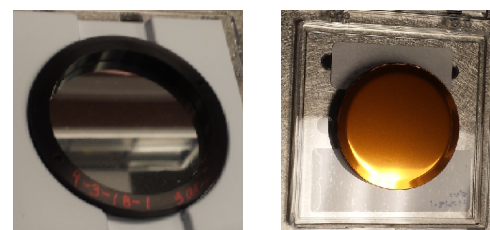
- BRDF scales for specular/polished surface
- Methodology of extracting the parameters of ABg models by taking into account of deconvolution of light beam profile and detector aperture.
- Determination of roughness parameters for smooth surfaces (microroughness)
- Used to predict the stray light performance of an optical system



**WFIRST**  
Wide Field Infrared Survey Telescope



**MLI: Multi-layer Insulation**

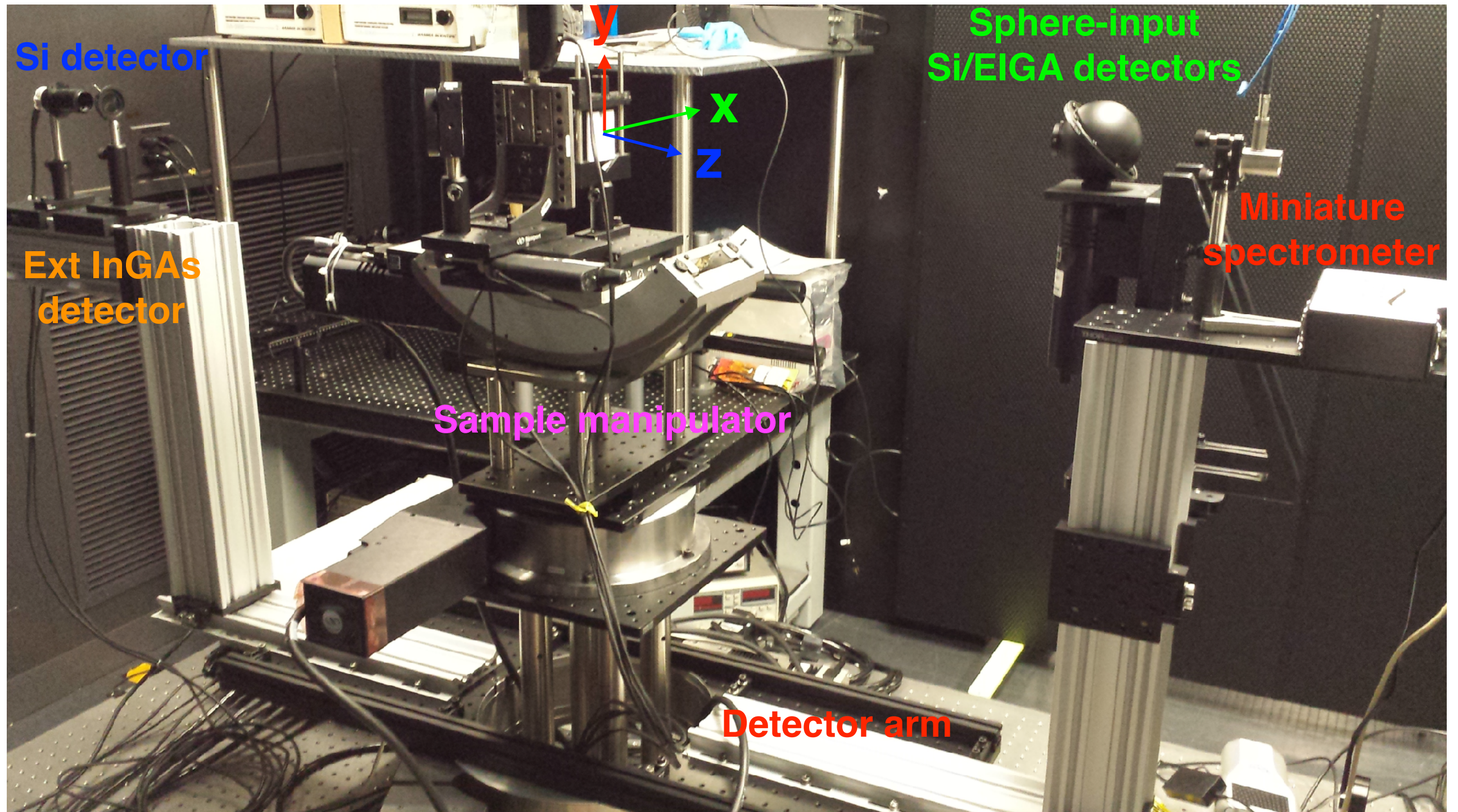


**Dark mirror coating**



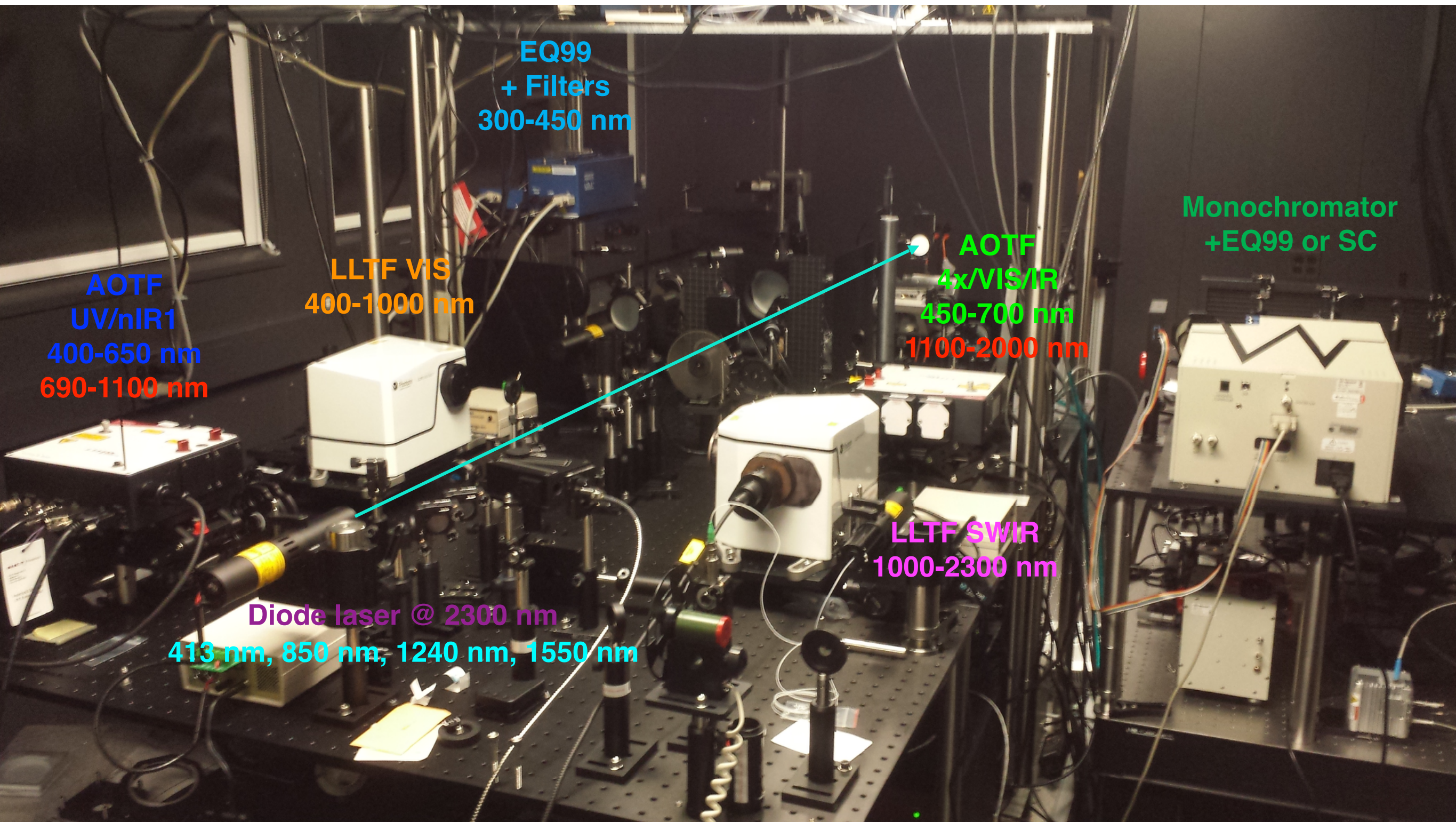


# Table Top Goniometer (TTG)





# TTG Light Sources



**AOTF with power lock + multiple line output**

**LLTF automated line selection**



# **Summary of BSDF results from selected smooth surface samples**



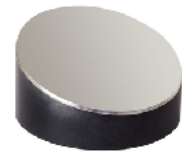
# Smooth samples: Flat and curved surfaces

PACE OCI

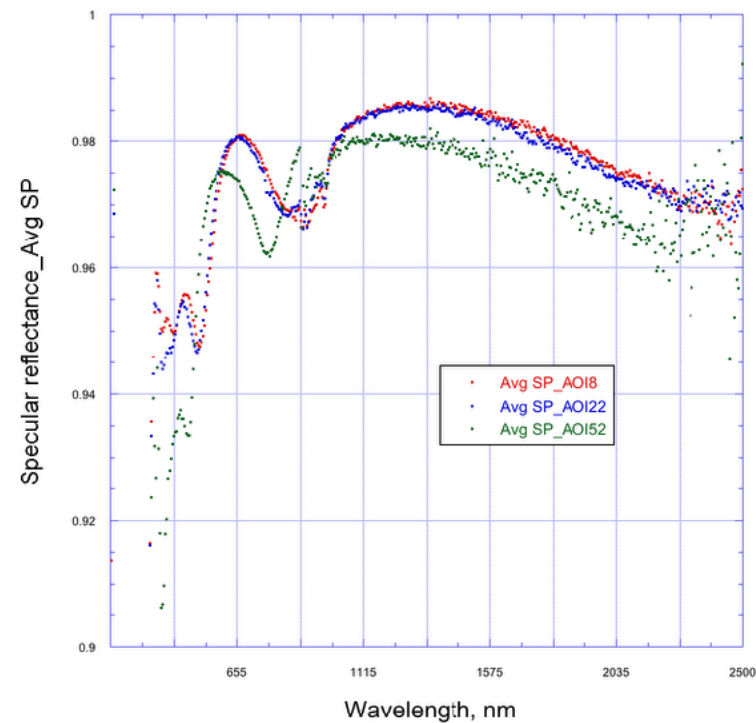
Flat mirror



OAP

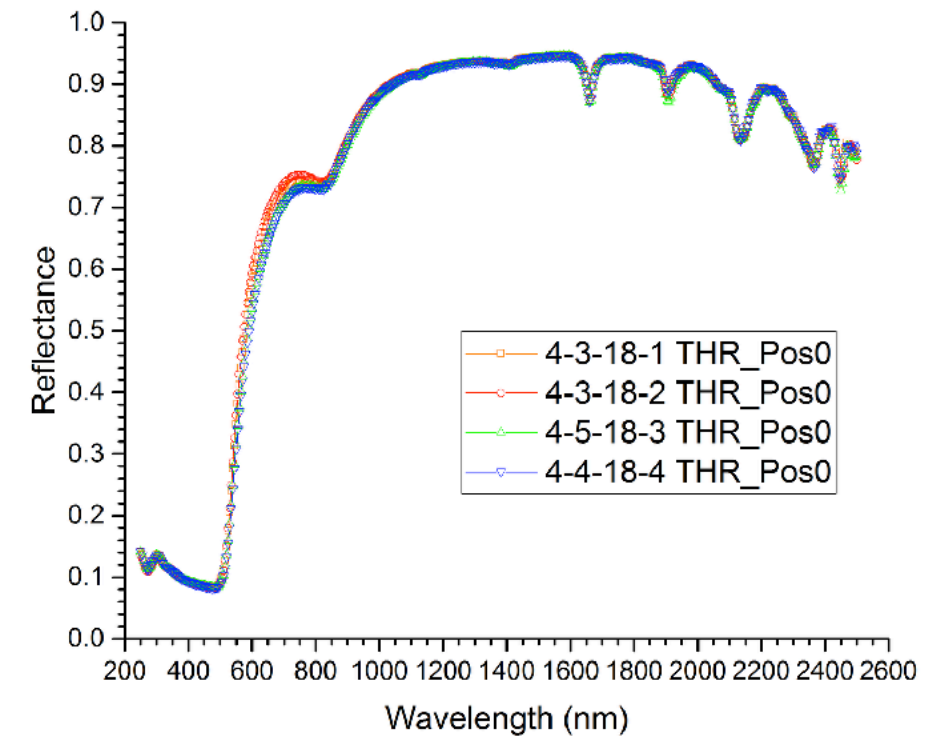
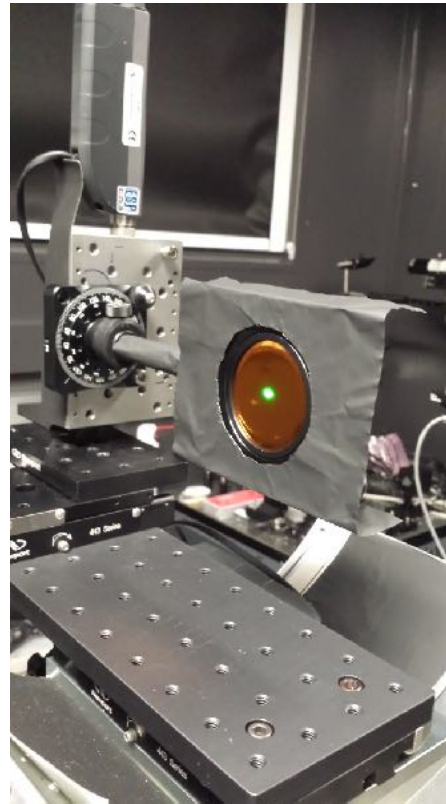


OCI Fold Flat Mirror by Corning (witness sample), Average Reflectance

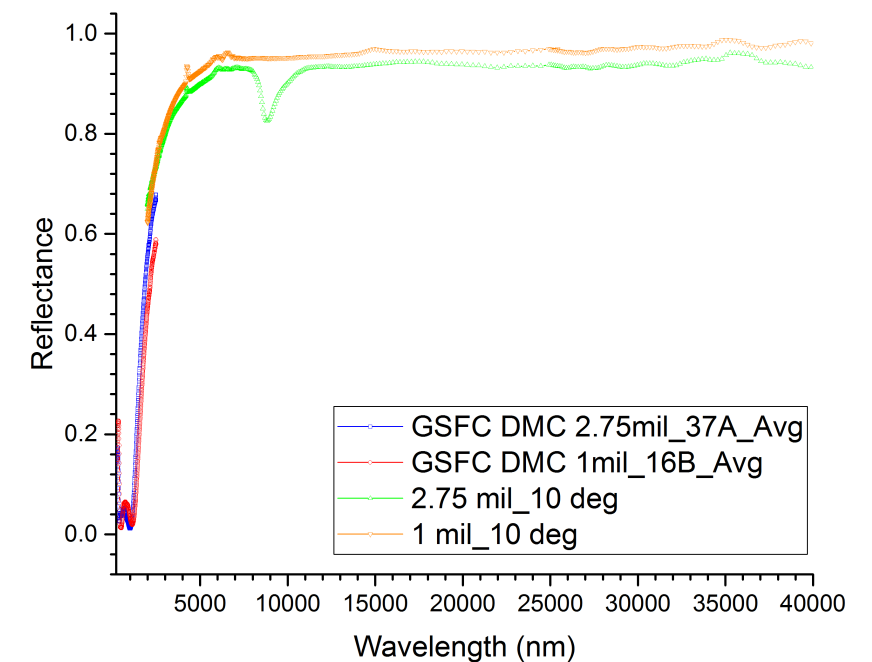
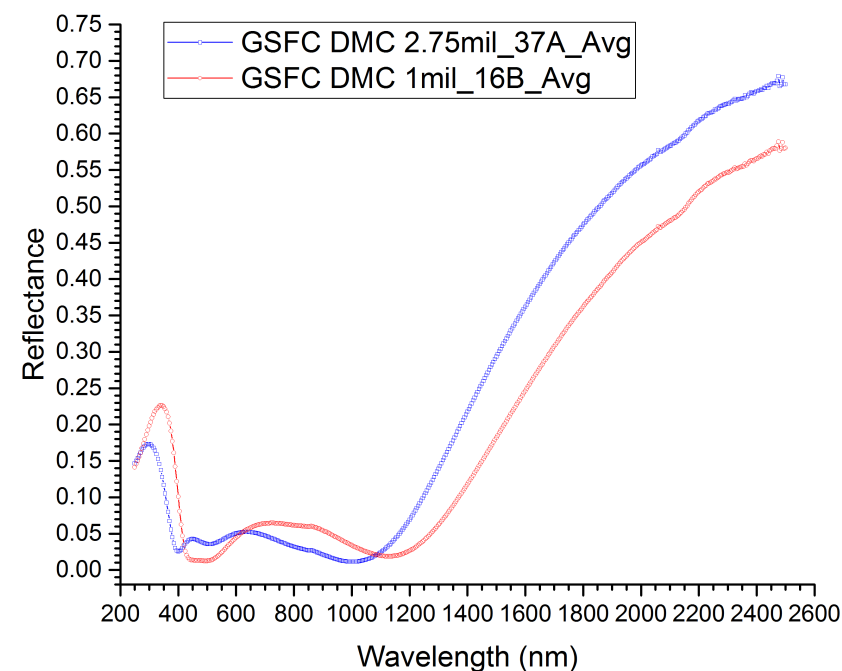
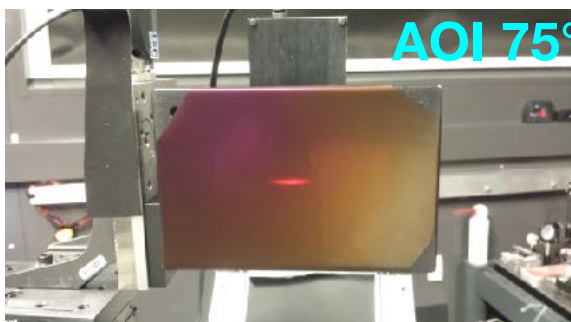
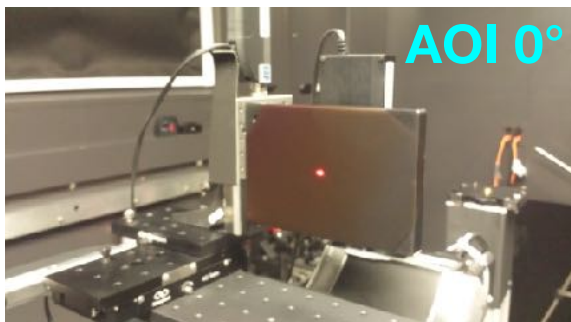


RestoreL

MLI

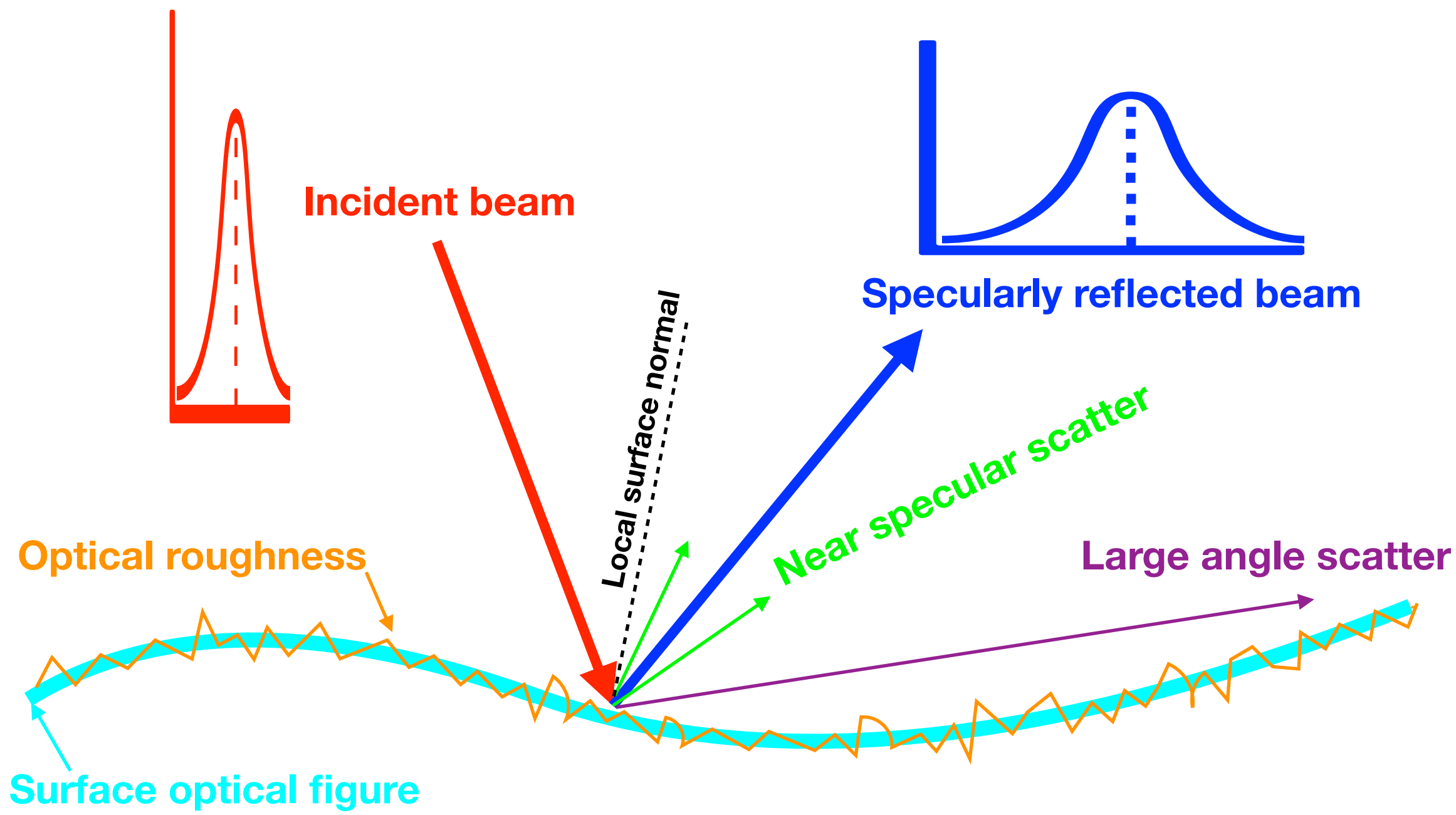


WFIRST DMC



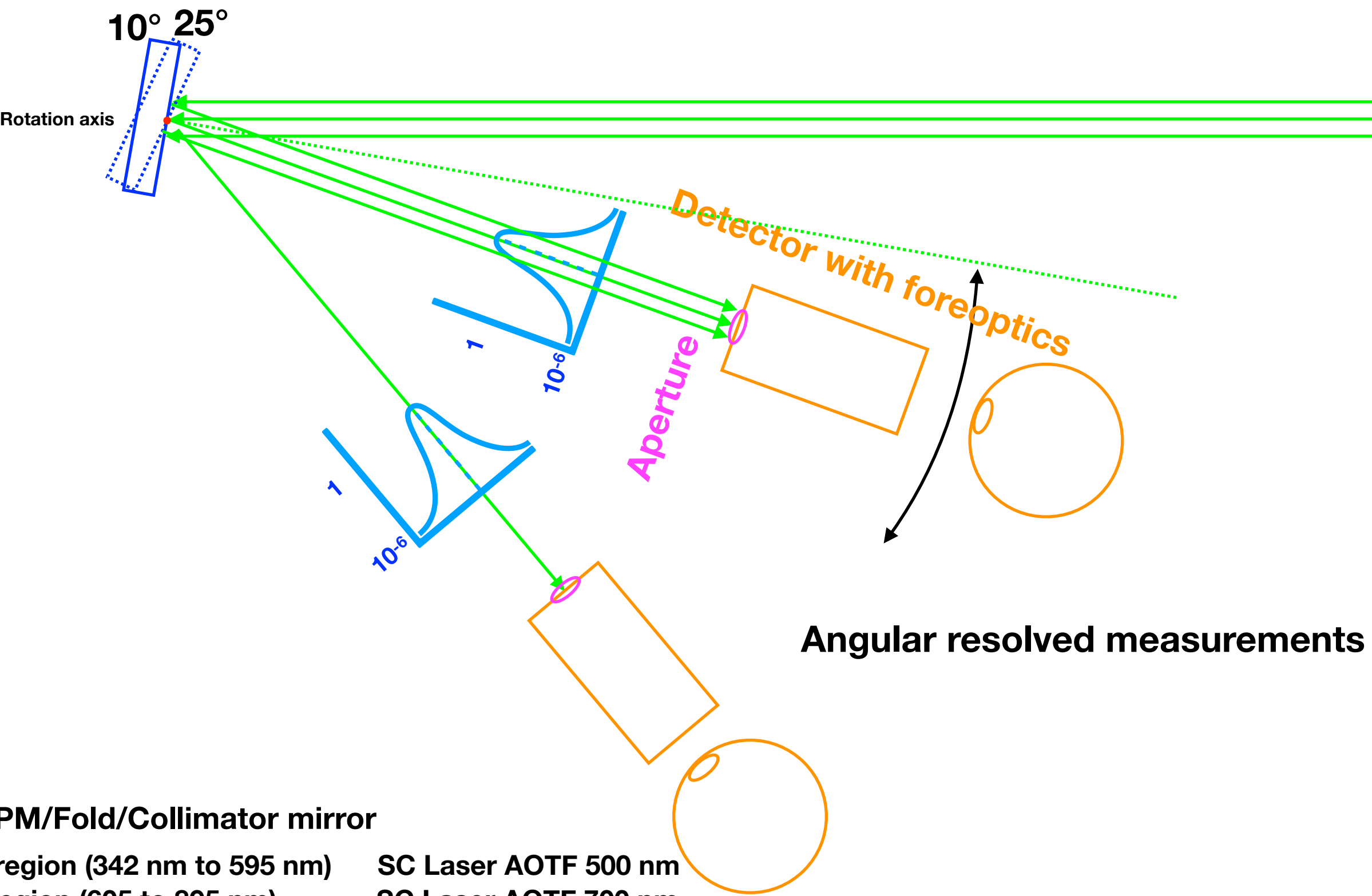


# Scattering from smooth surface with optical figure and roughness





# Schematic diagram of BSDF measurement for flat surface sample



OCI PM/Fold/Collimator mirror

Blue region (342 nm to 595 nm)

Red region (605 to 895 nm)

SWIR region (2250 nm)

SC Laser AOTF 500 nm

SC Laser AOTF 700 nm

Diode laser

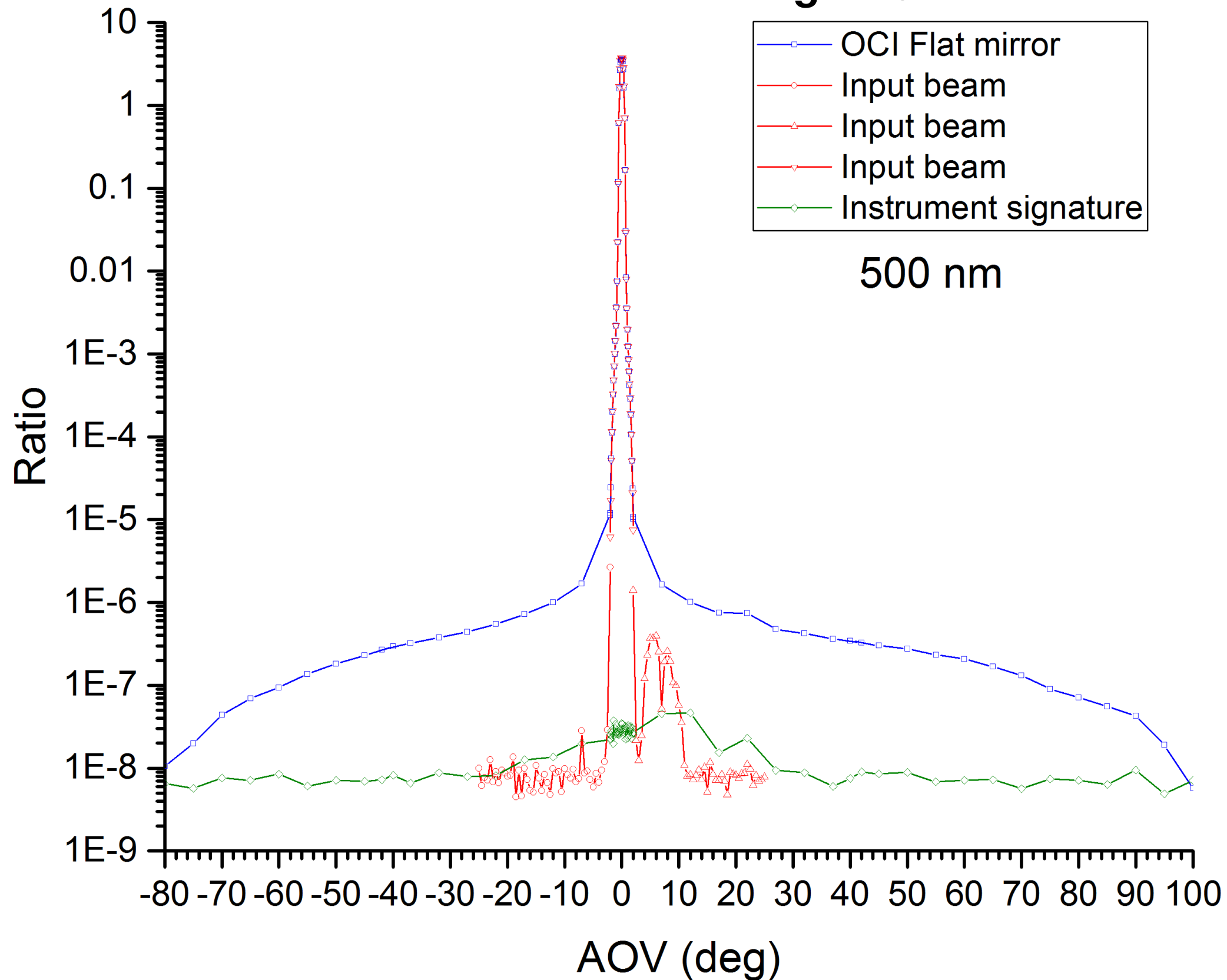


# Validation of specular reflectance of the Flat Mirror from TTG

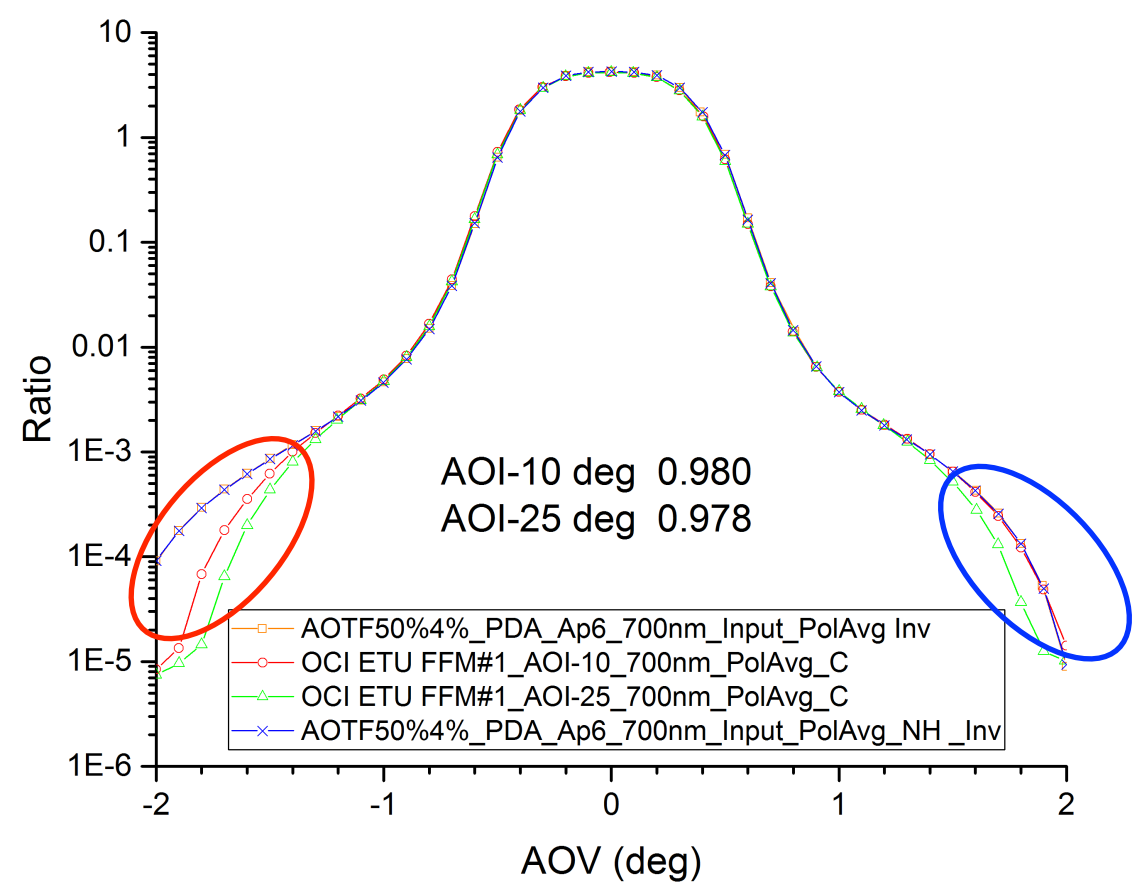
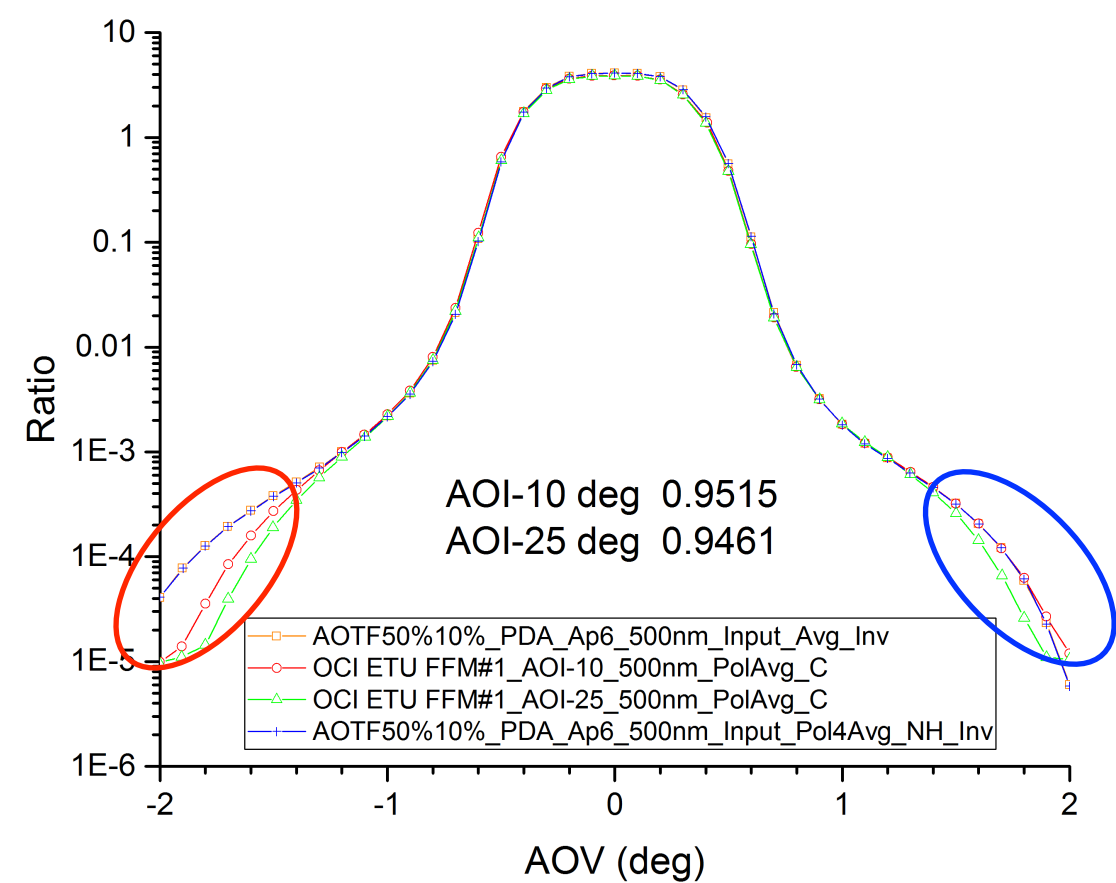
	10° (TTG)	8° (URA)	25° (TTG)	22° (URA)
500 nm	0.9515	0.9507	0.9461	0.9476
700 nm	0.980	0.9802	0.978	0.9794
2000 nm	0.975	0.9760	0.9774	0.9747



# Comparison of signal levels of input, scatter, and instrument signature for a flat mirror using TTG

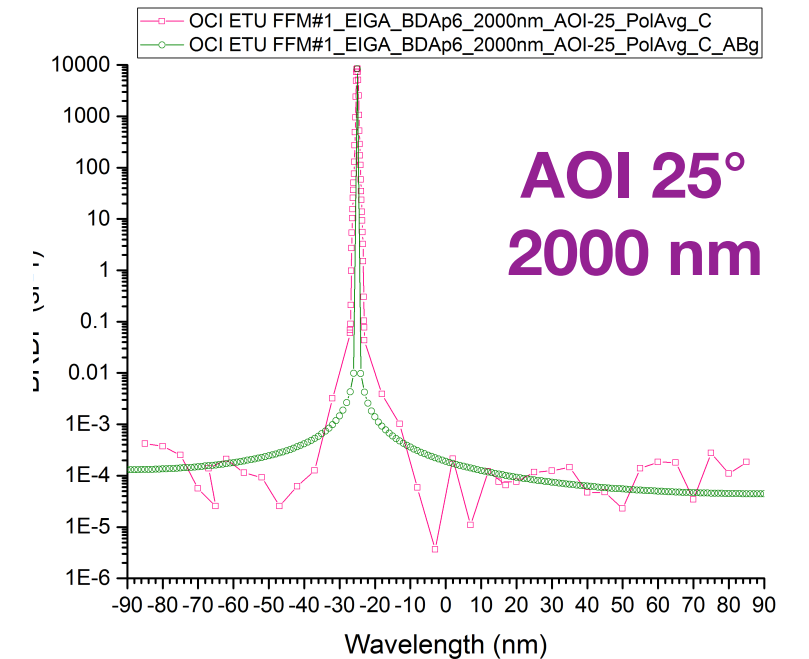
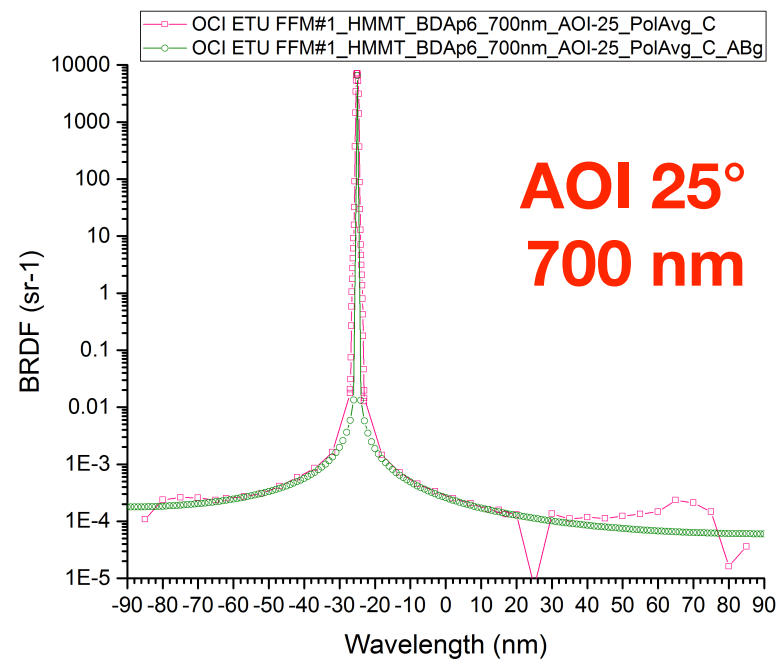
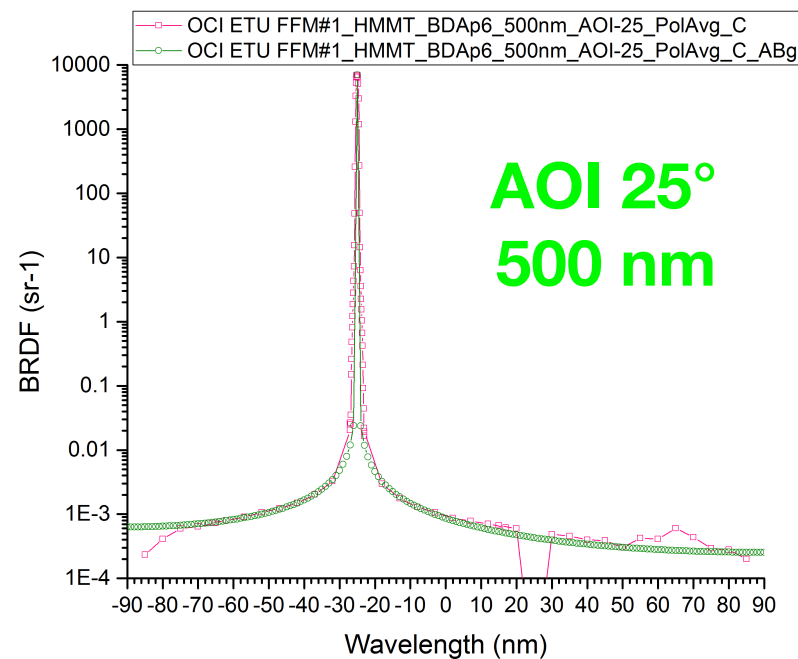
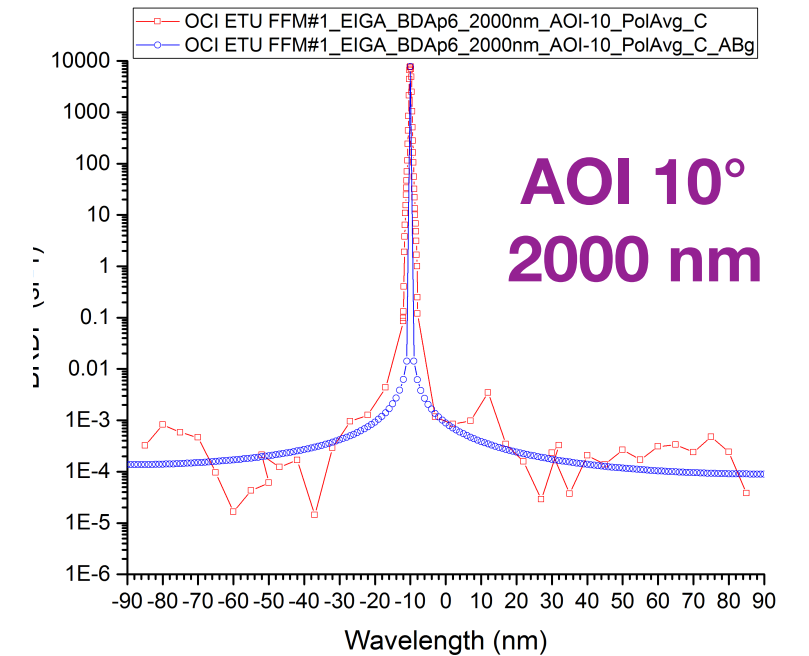
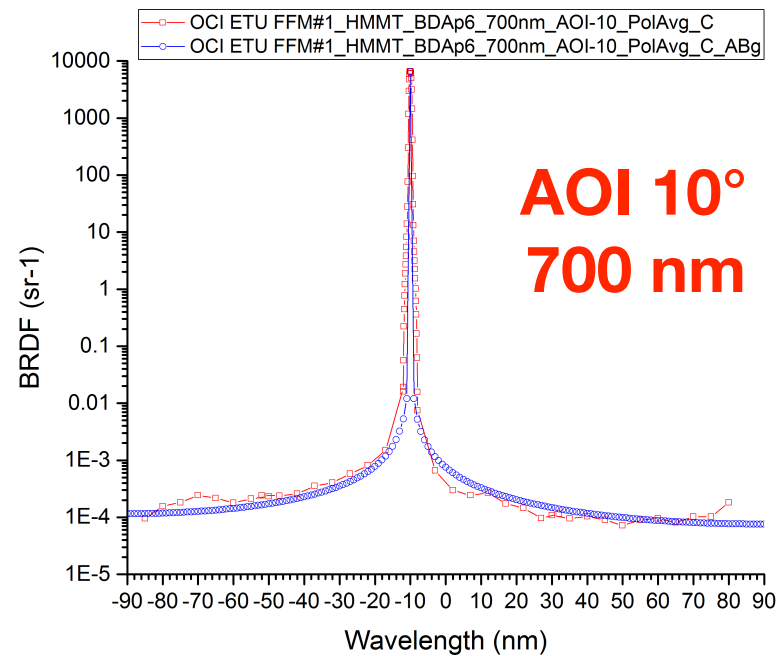
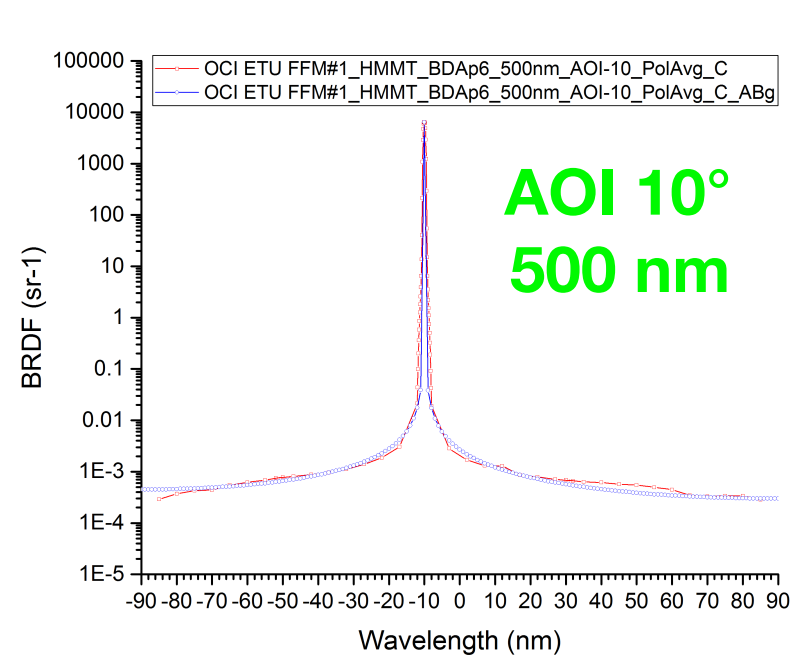


# Comparison of input beam and reflected peak from a flat mirror

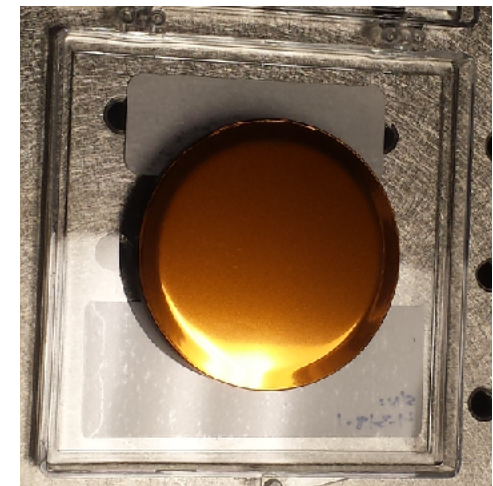
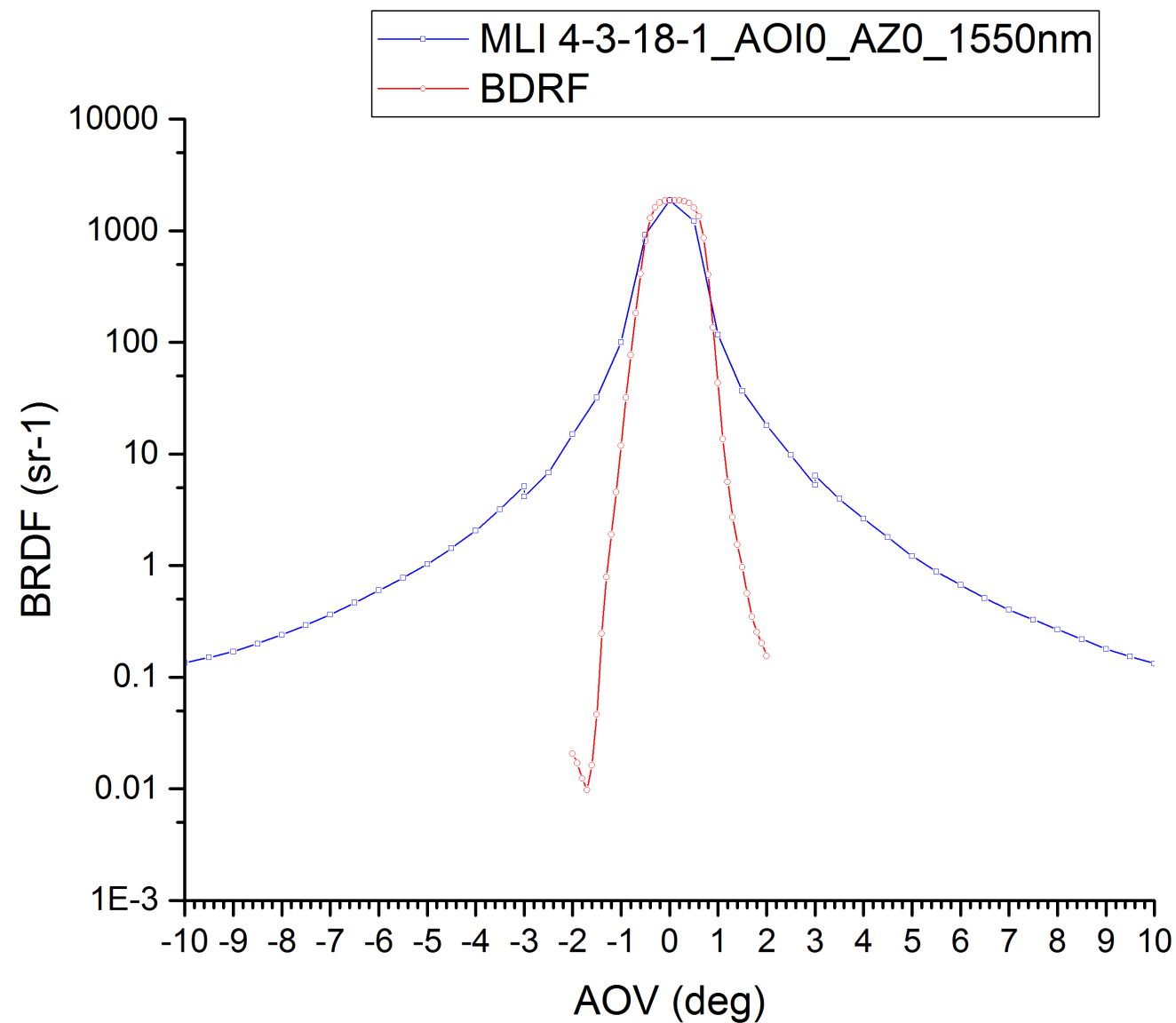




# OCI flat mirror BSDF results at 500, 700 and 2000 nm and direct ABg model fittings



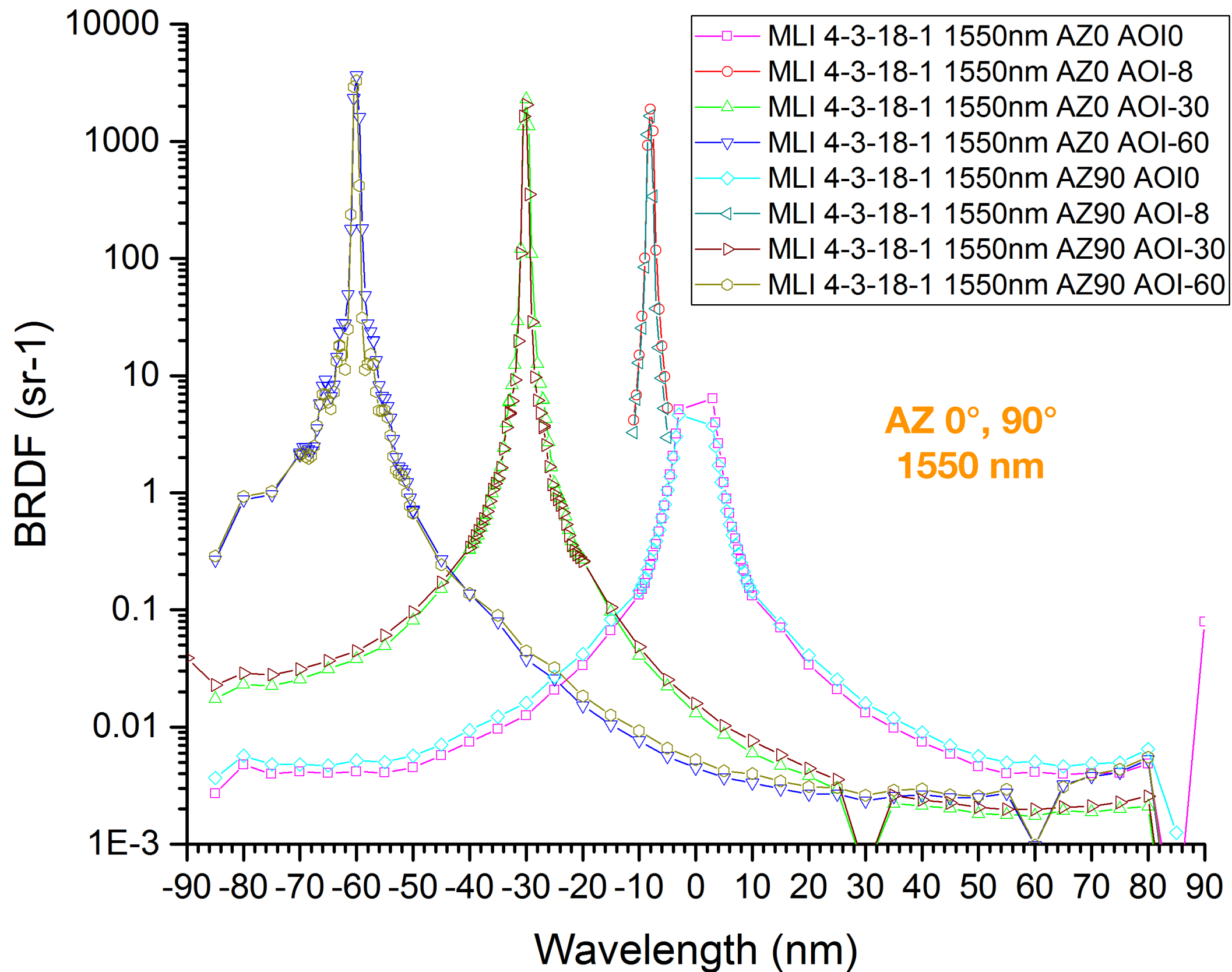
# Comparison of input beam and reflected beam from MLI



**Case II Large surface optical figure**  
**Input beam  $\sim$  Reflected peak**

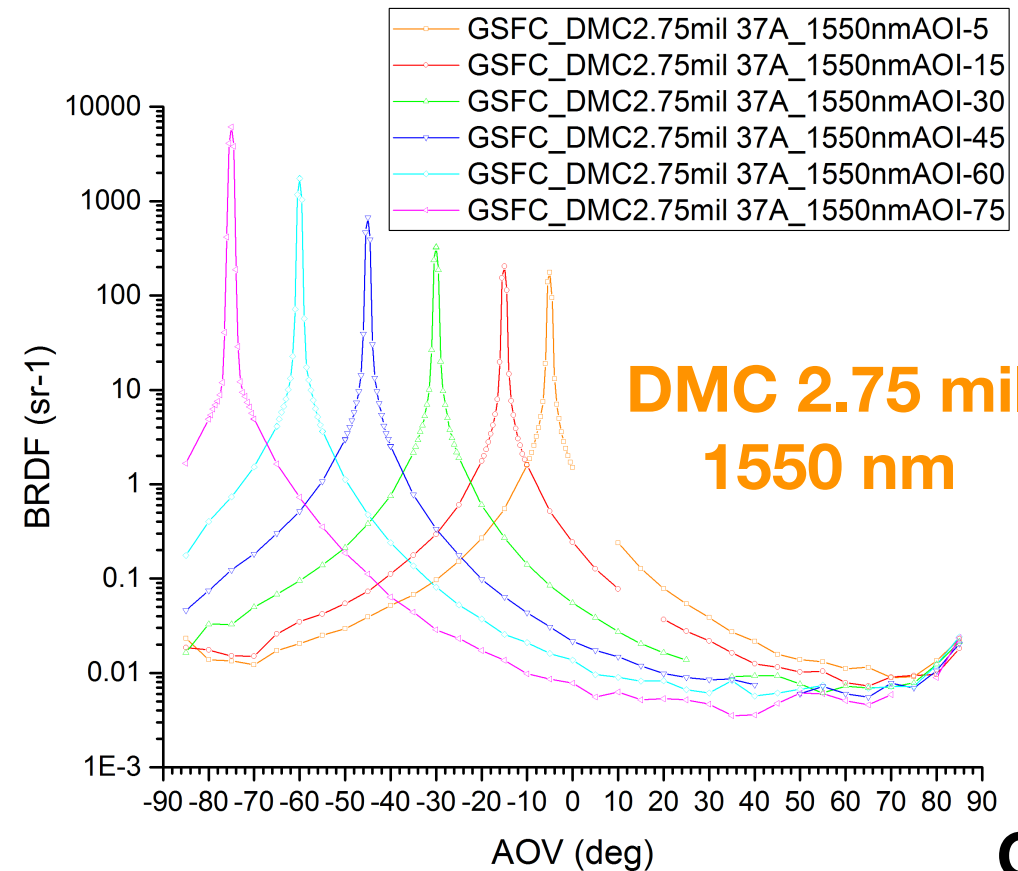
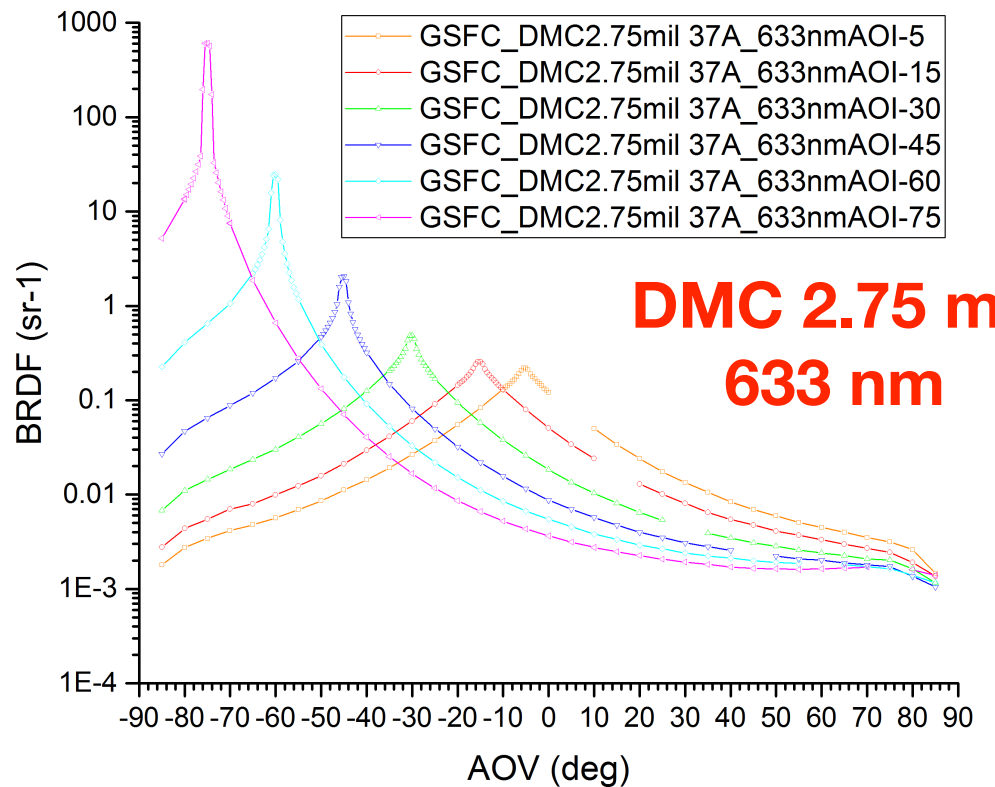
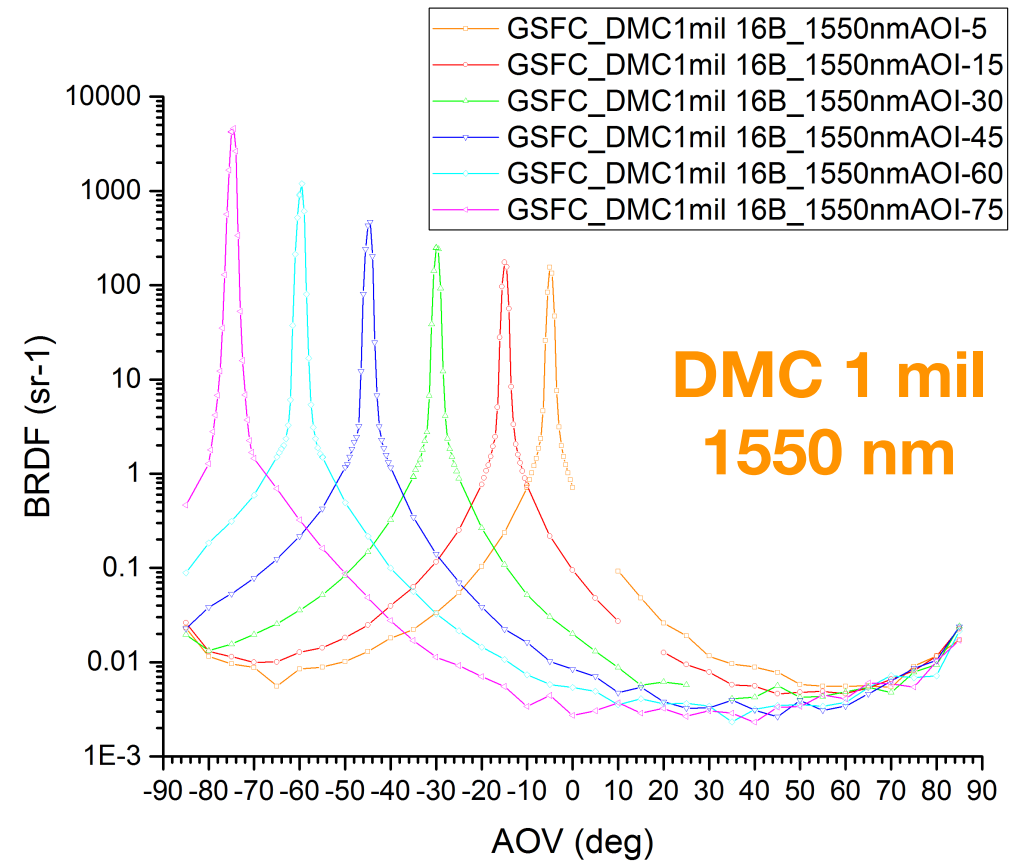
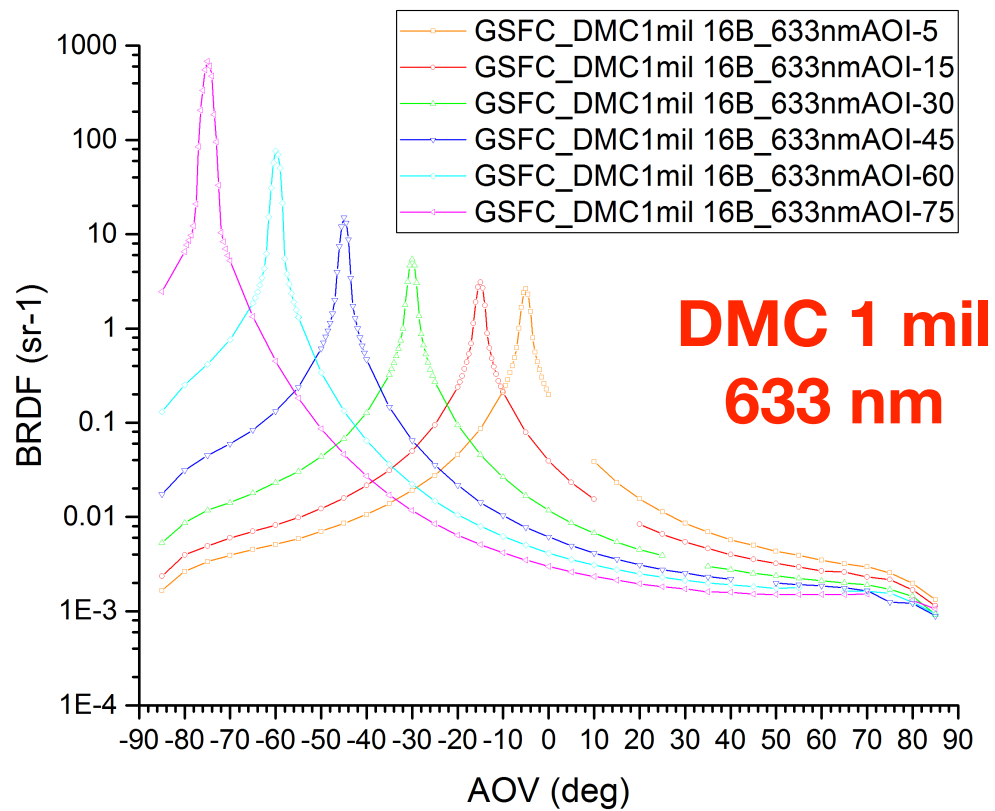


# RestoreL MLI BSDF at 1500 nm with AOI 0, 8, 30, 60°



Case II

# BSDF results at AOIs of 5, 15, 30, 45, 60, 75° of GSFC DMCs

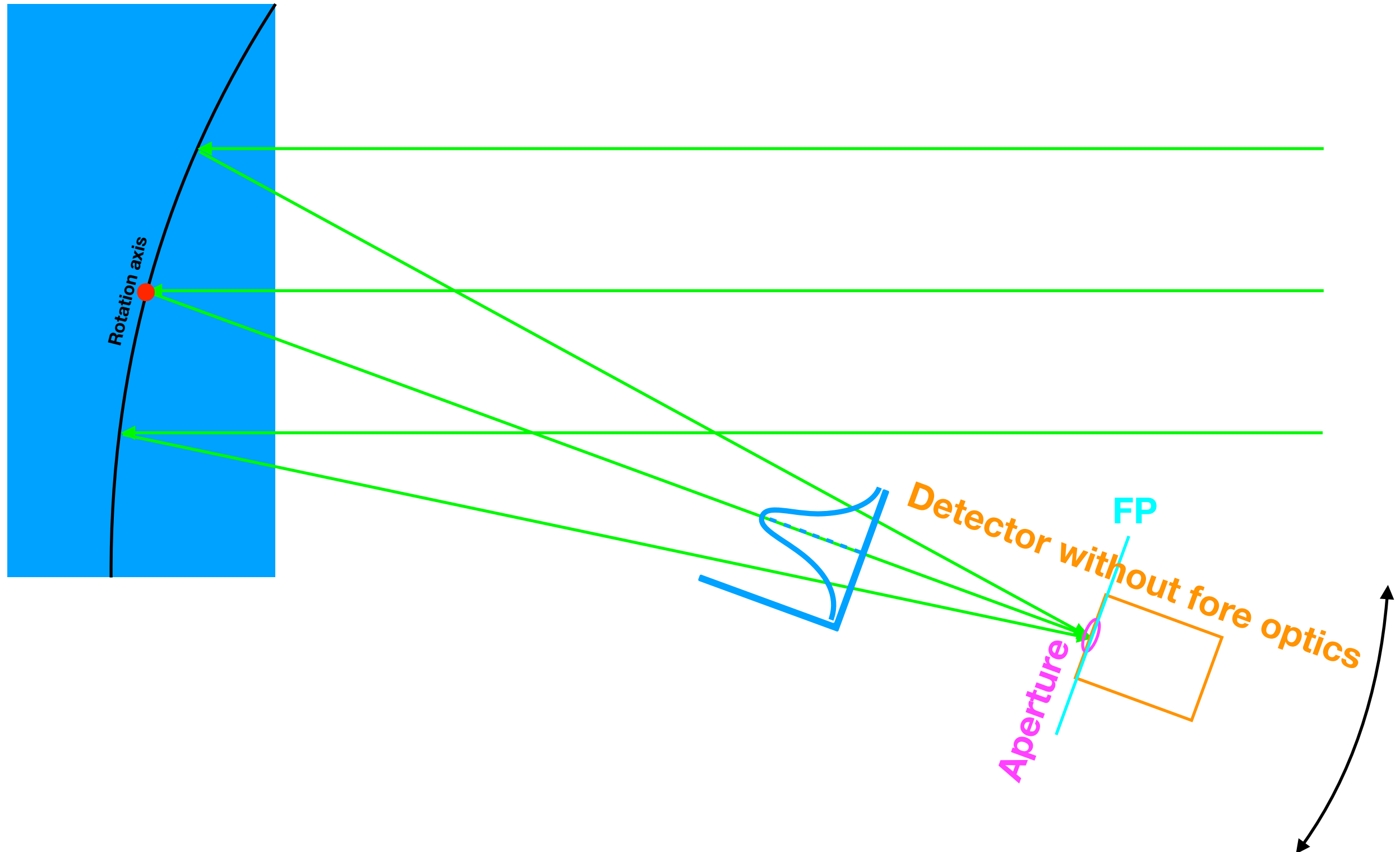




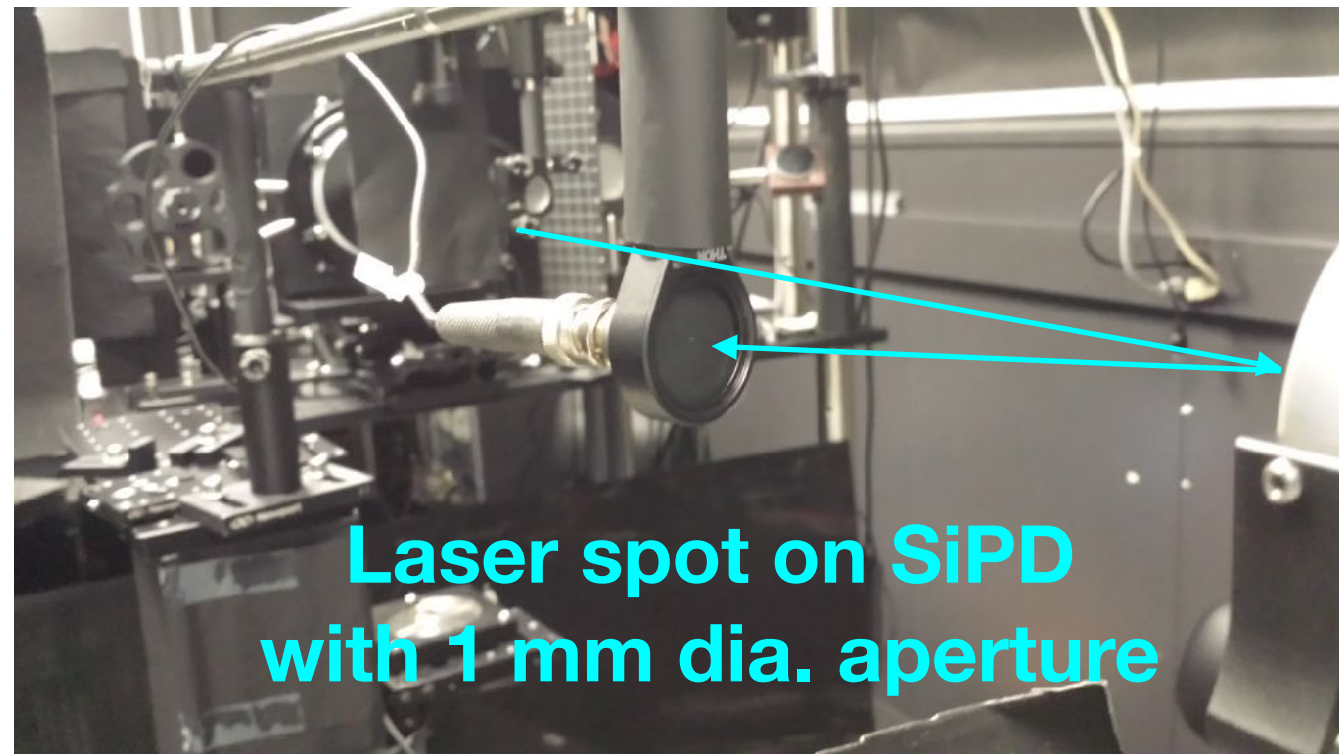
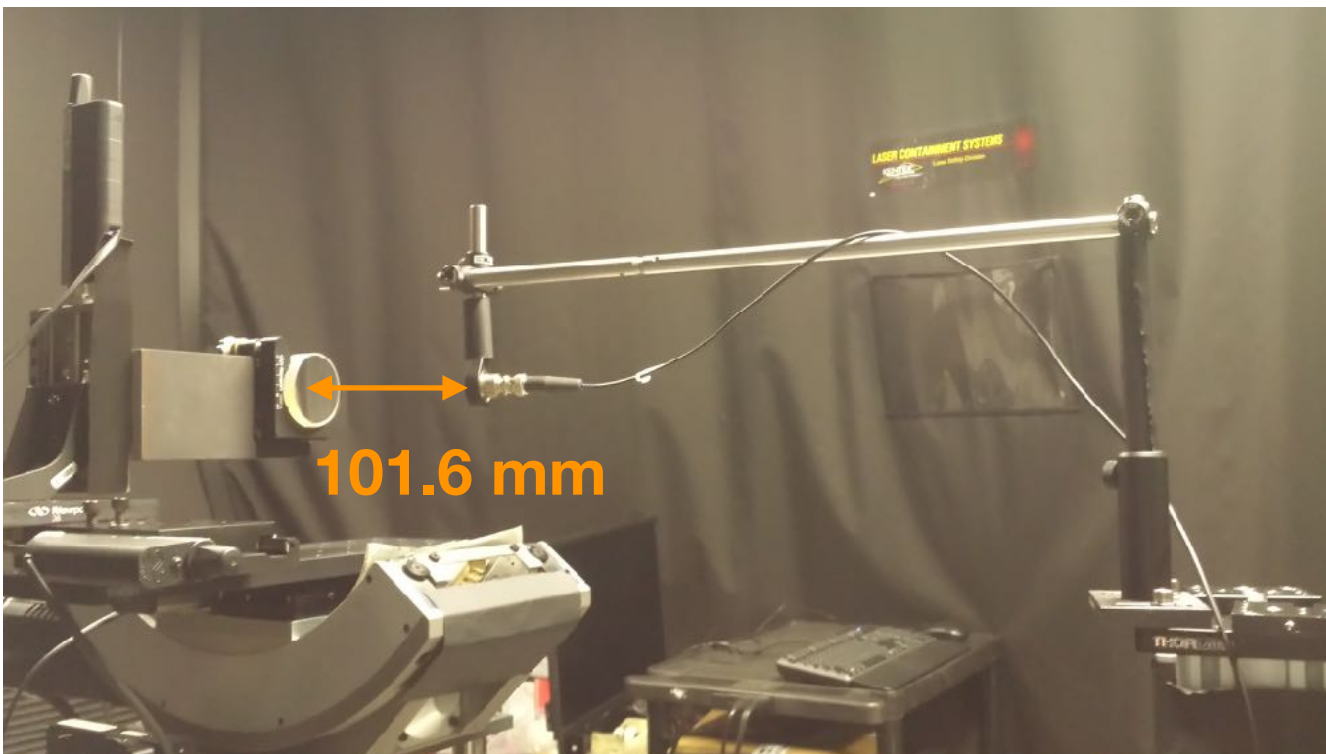
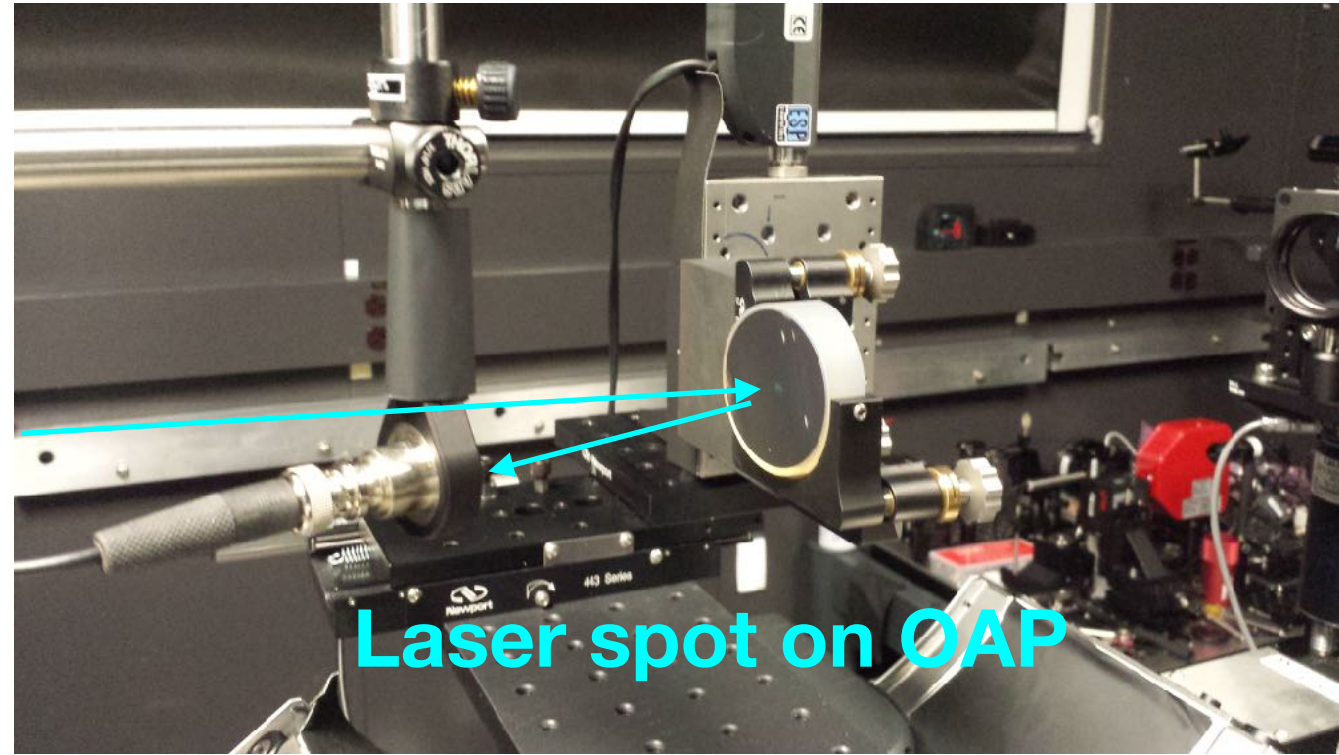
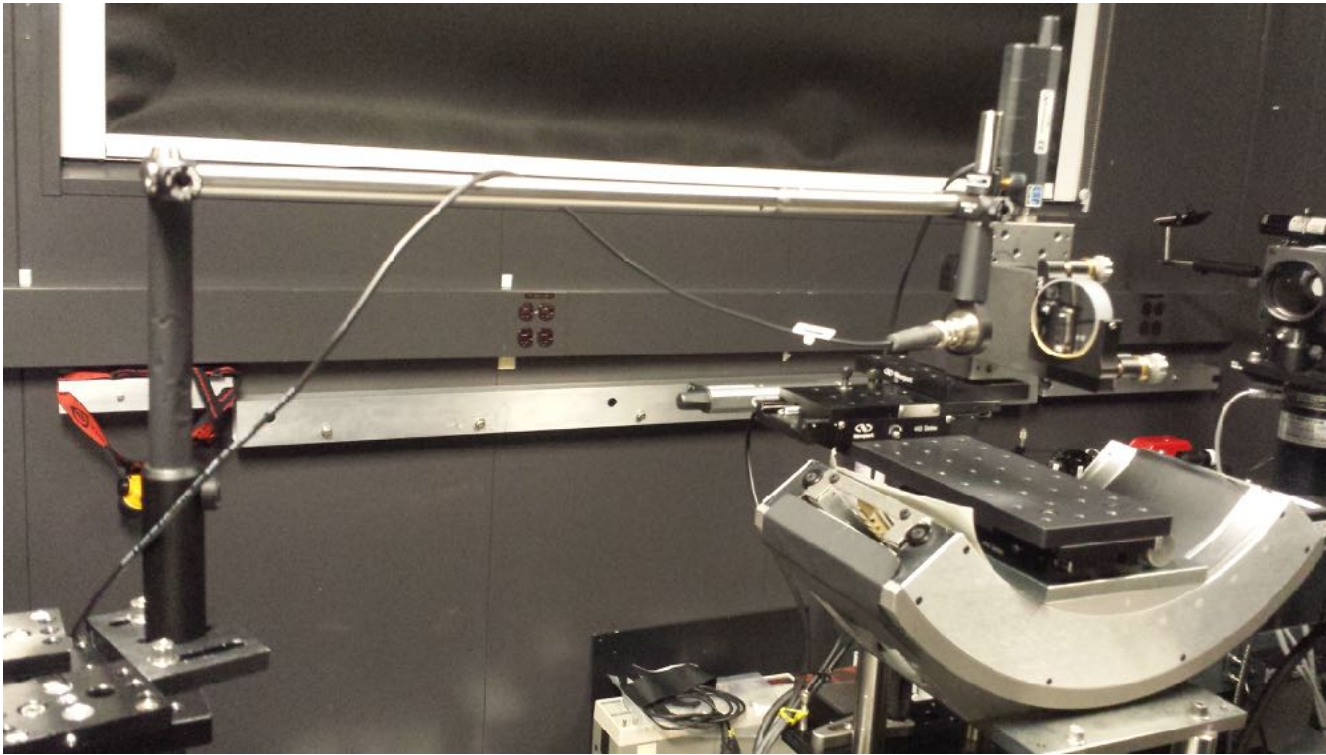
# Schematic diagram of BSDF measurement for curved surface

20.1° OAP

A radius of curvature of 203.2 mm., 101.6 mm focal length

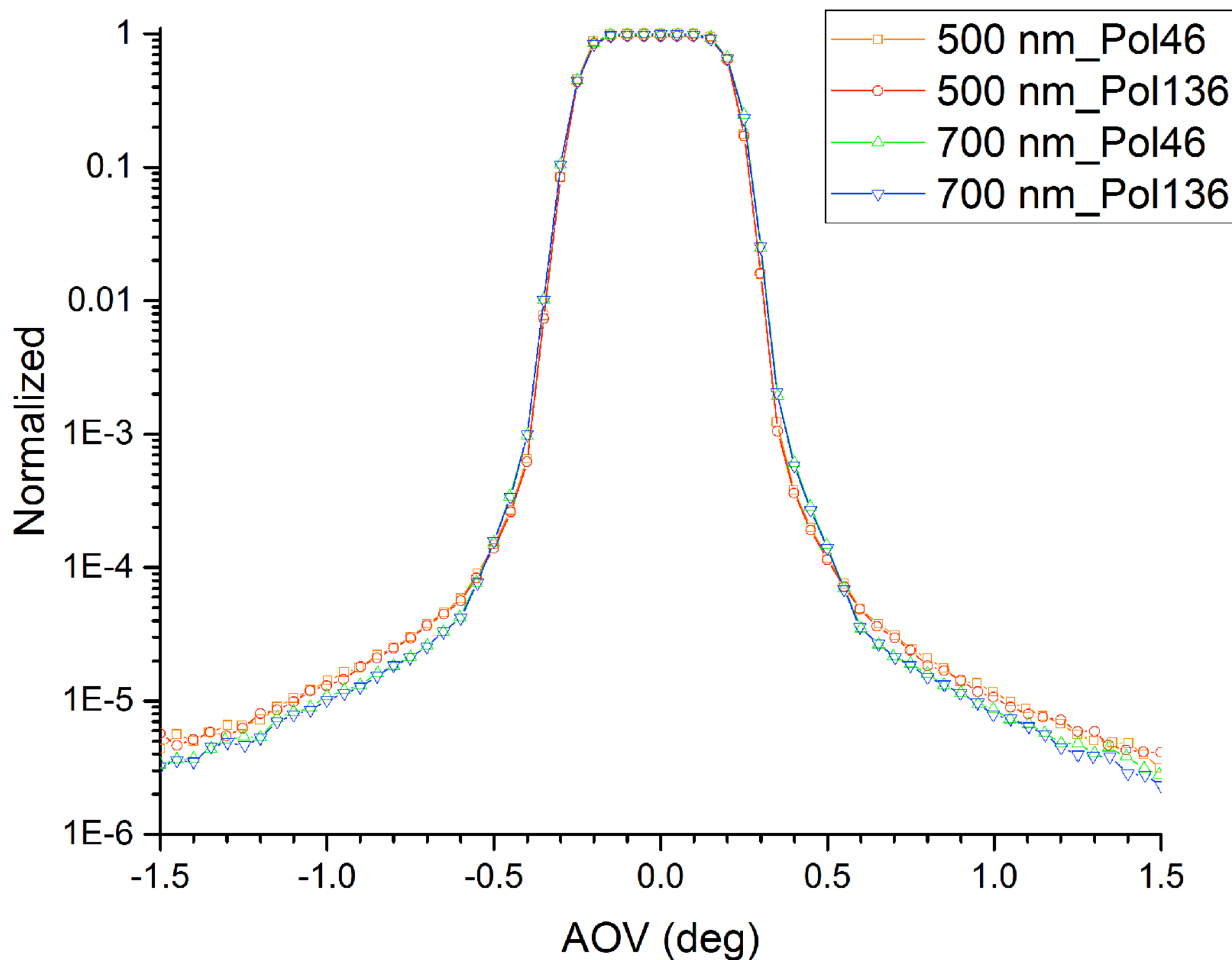


# Setup of BSDF measurement for OAP mirror





# Reflected peak profile of OCI OAP mirror



# **BSDF data analysis using ABg model**

- 1. Direct ABg model fittings**
- 2. Determination of ABg parameters using deconvolution**

# ABg model

The ABg model is widely used to describe scatter from smooth optical surfaces in most optical design and engineering software. The model is typically written:

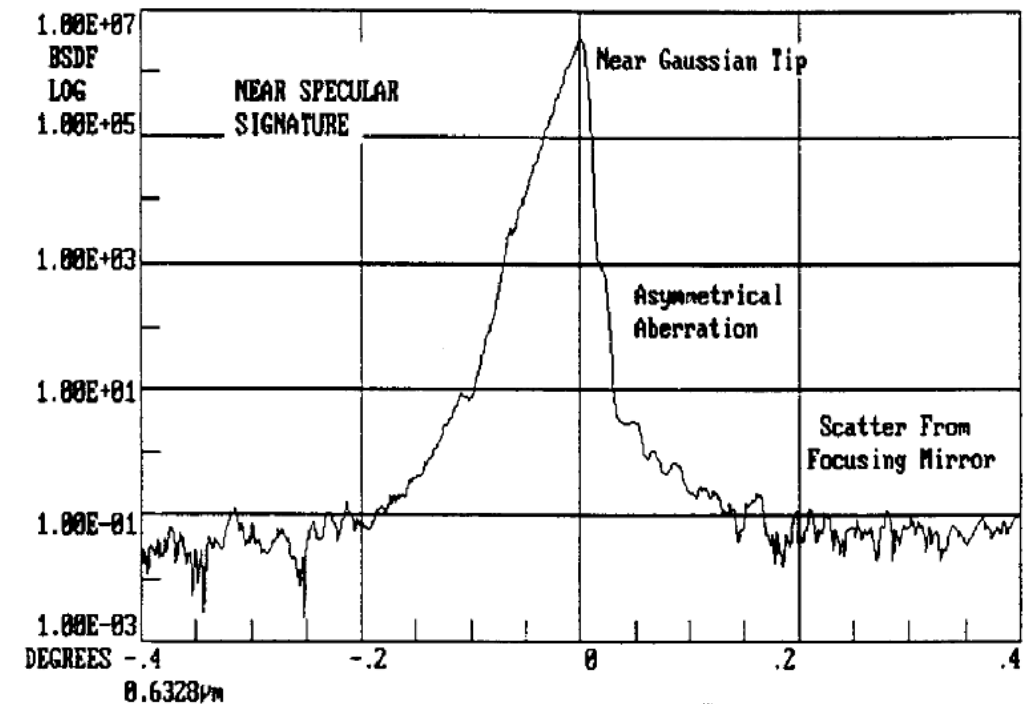
$$BSDF(\beta - \beta_0) = \frac{A}{B + (\beta - \beta_0)^g}$$

where

$$\beta = \sin \theta_{scatter} \quad \beta_0 = \sin \theta_{specular}$$

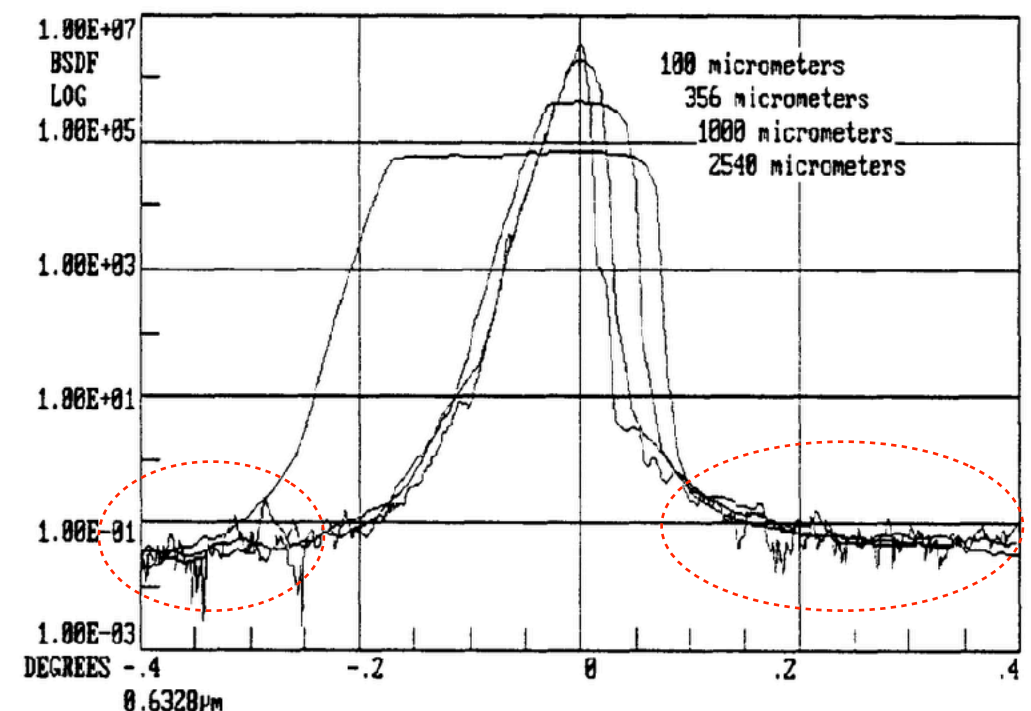
A, B, and g are the specific model parameters. The ratio of the A and B parameters is equal to the peak bidirectional scattering distribution function (BSDF) in the specular direction. The angle at which the BSDF transitions from a constant value to a power-law falloff is given by  $B^{1/g}$ . The slope g is identical to the power-law falloff of the 2-D power-spectral density (PSD) of the surface roughness.

Instrument signature and aberration.



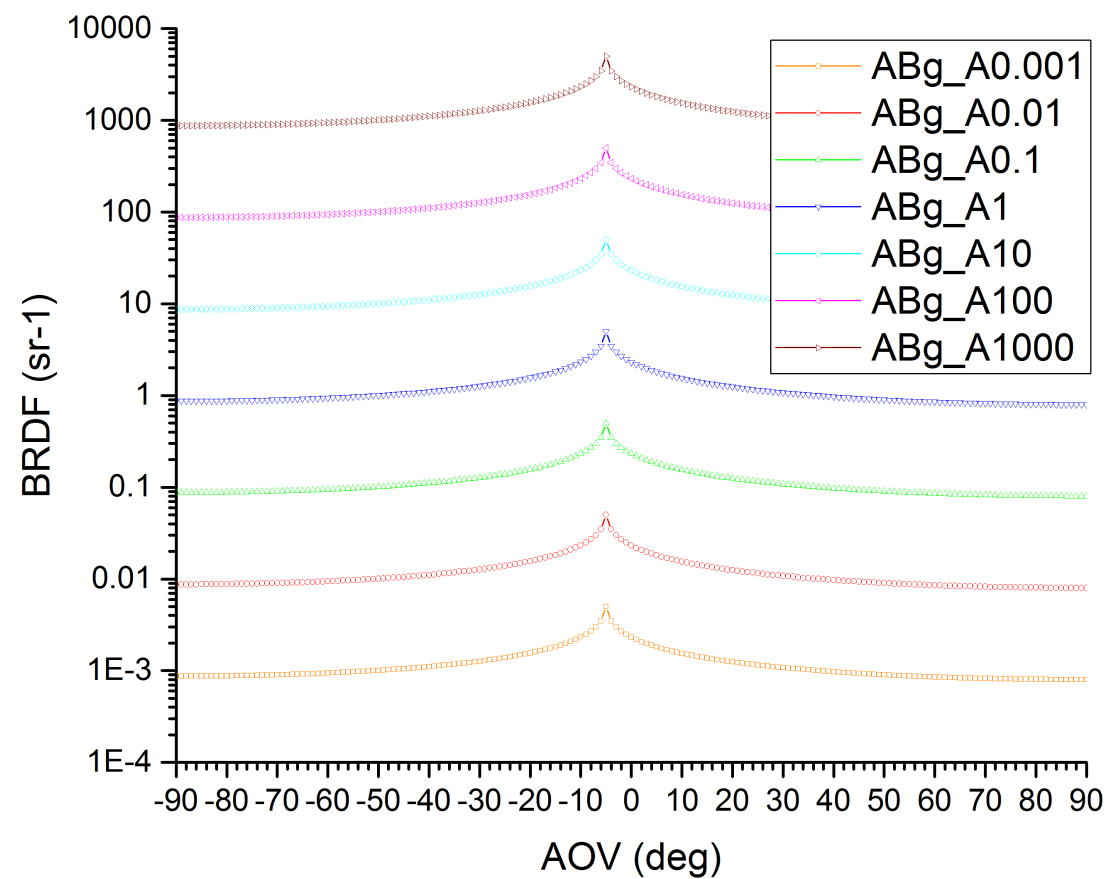
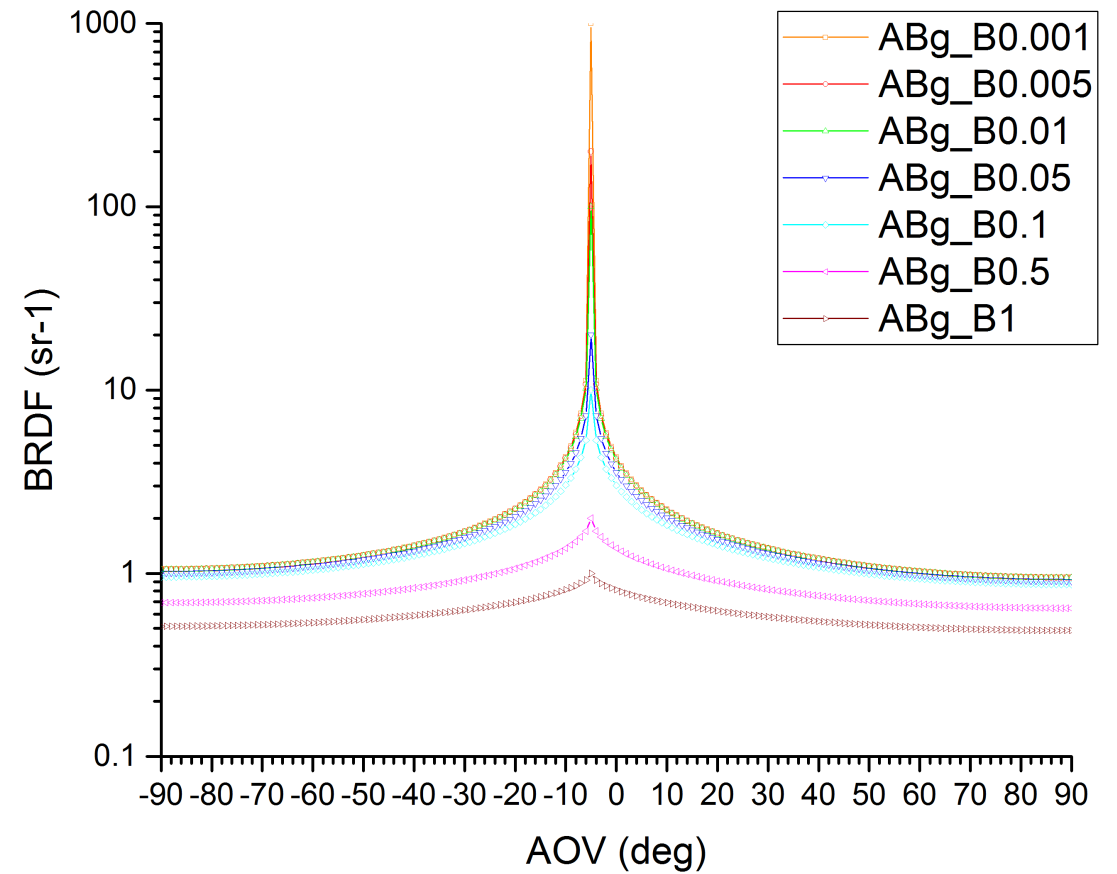
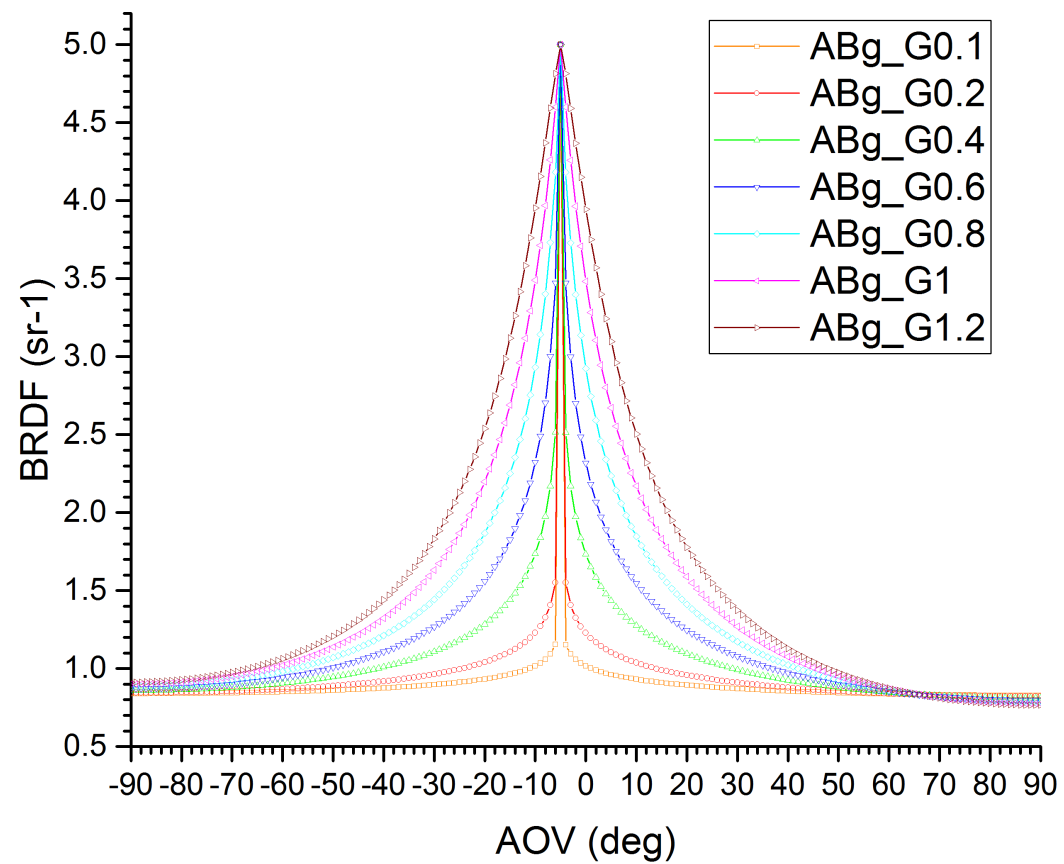
“Optical Scattering” by John Stover

The effect of aperture convolution on signature measurements.



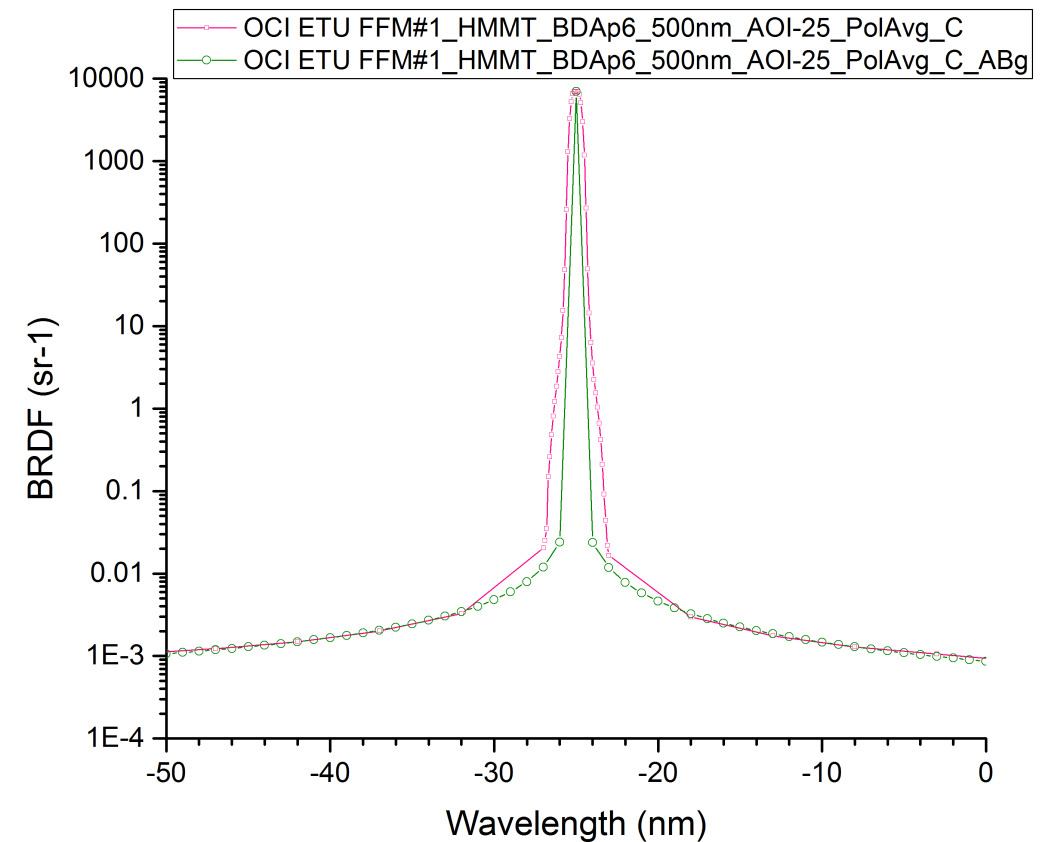
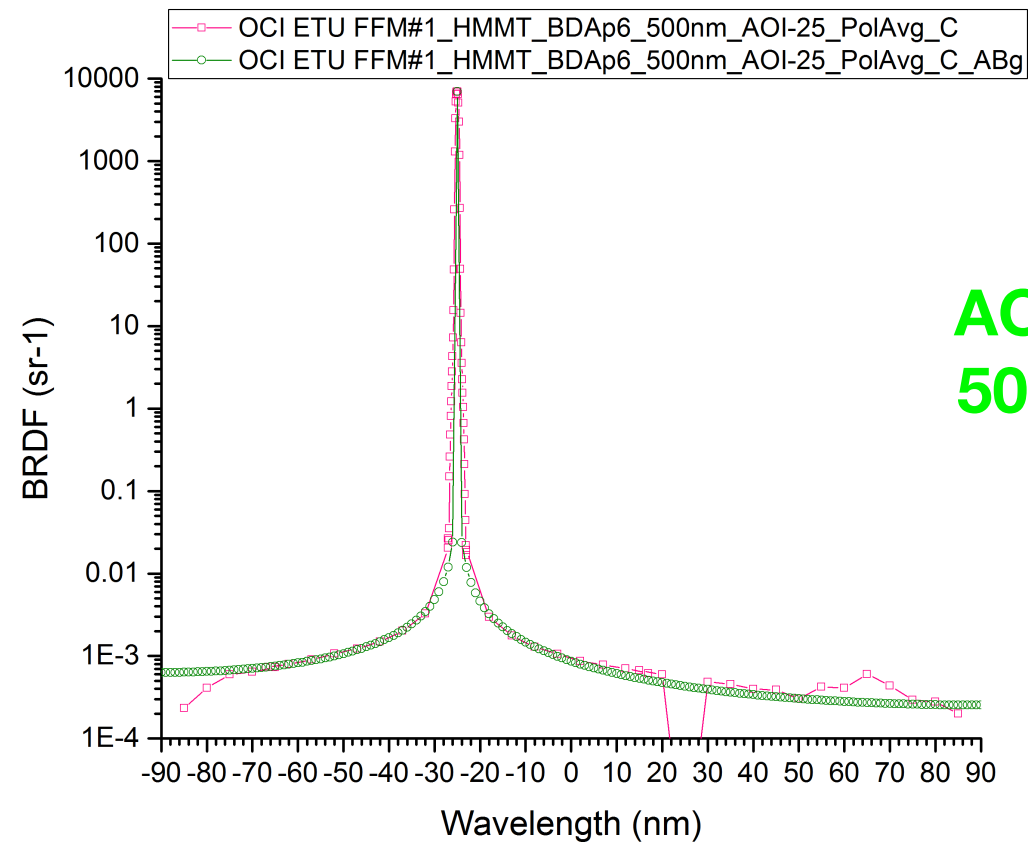
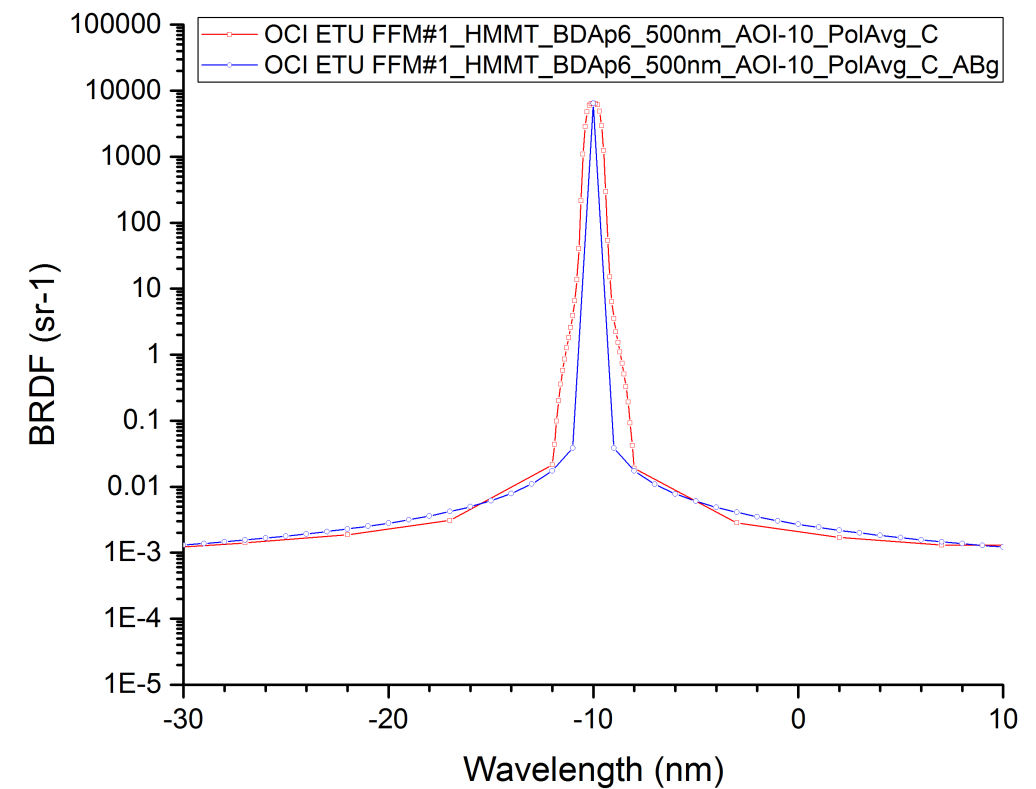
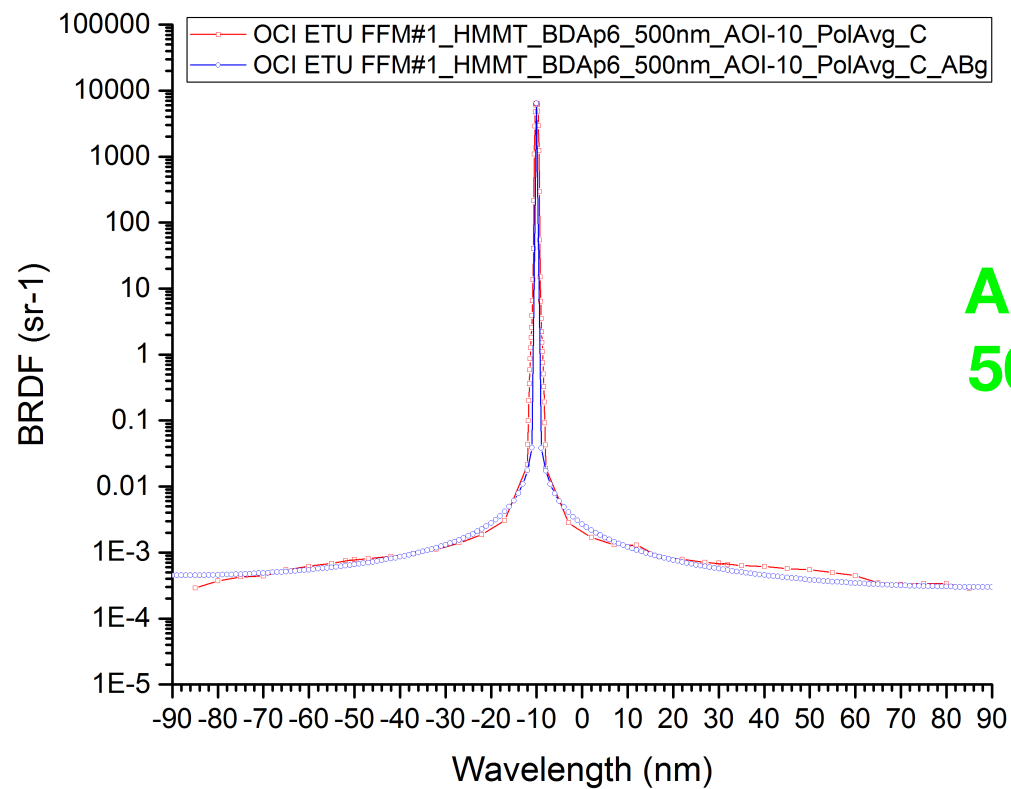


# ABg model simulation



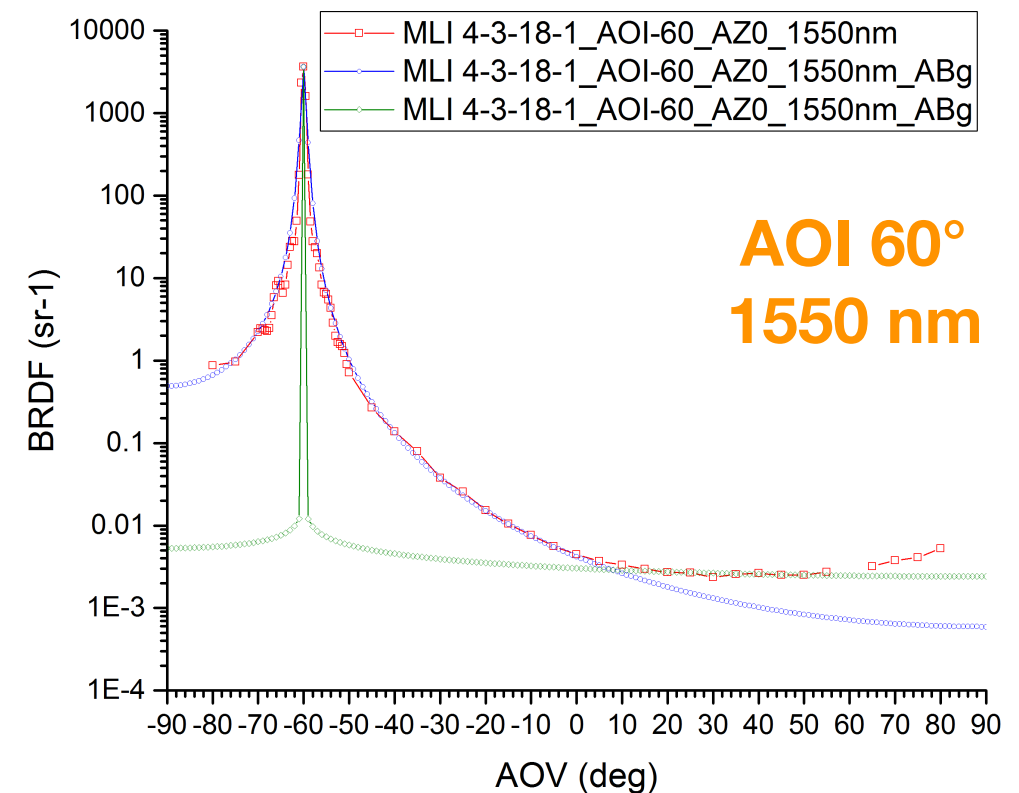
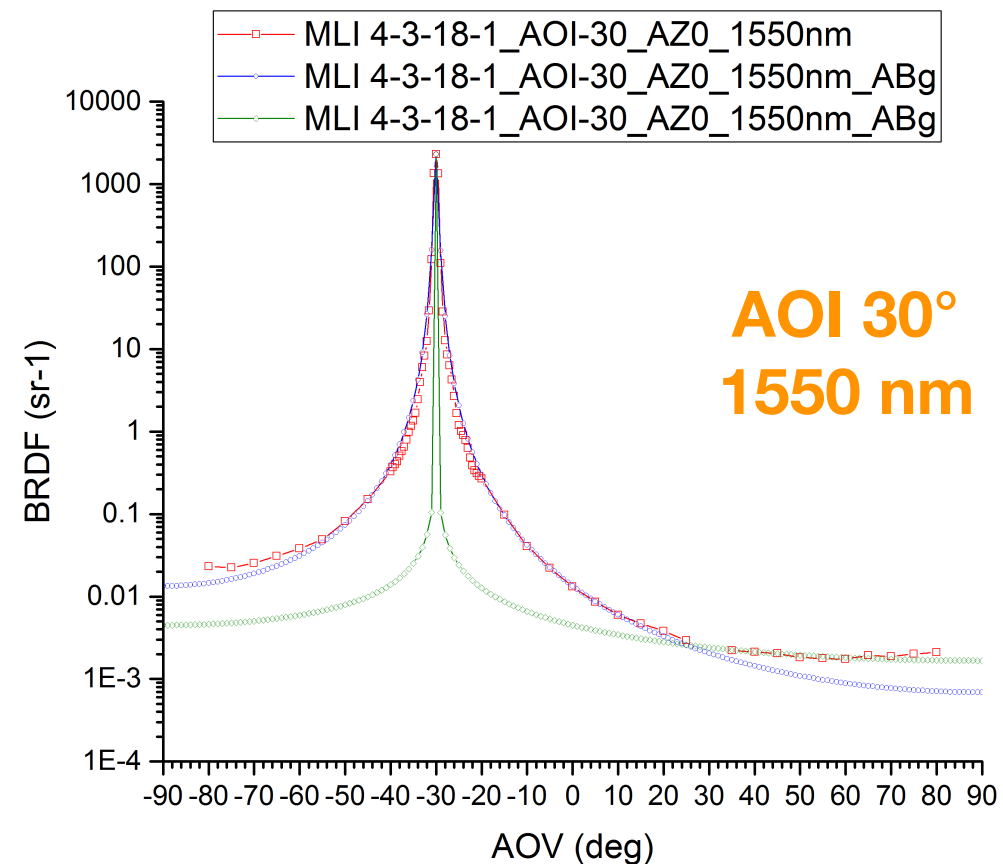
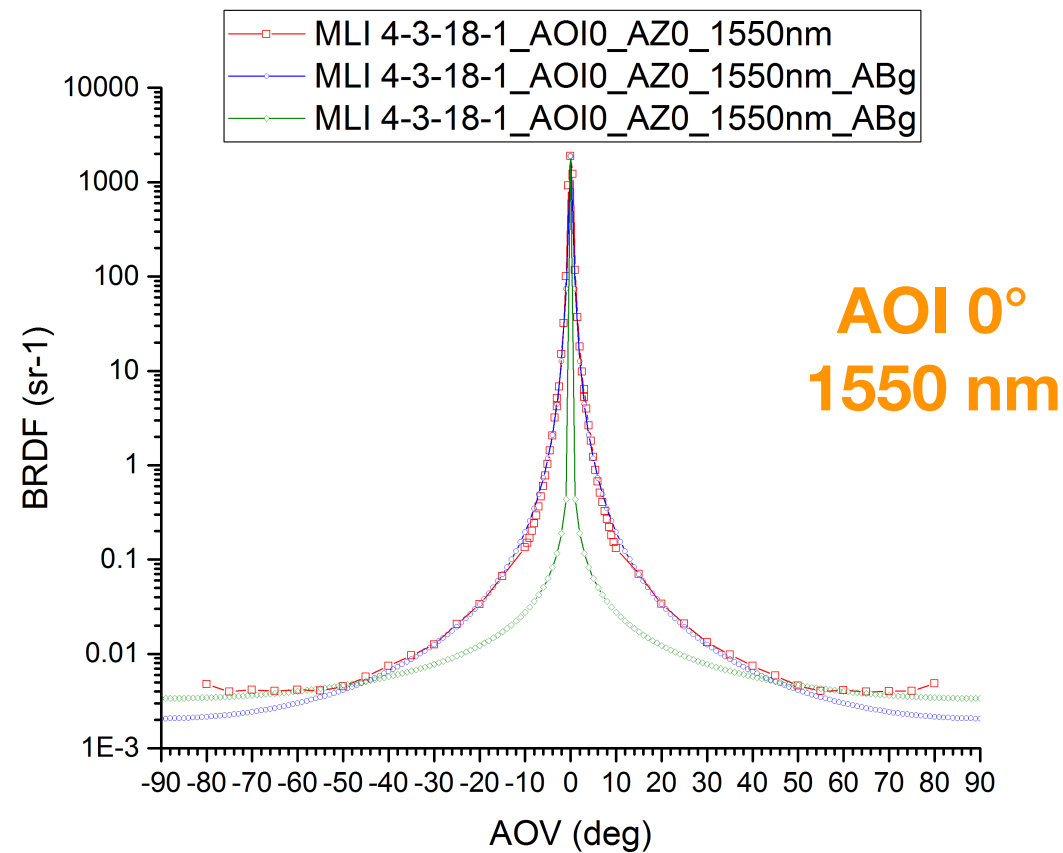
# **1. Direct ABg model fittings**

# OCI flat mirror BRDF data and direct ABg model fitting

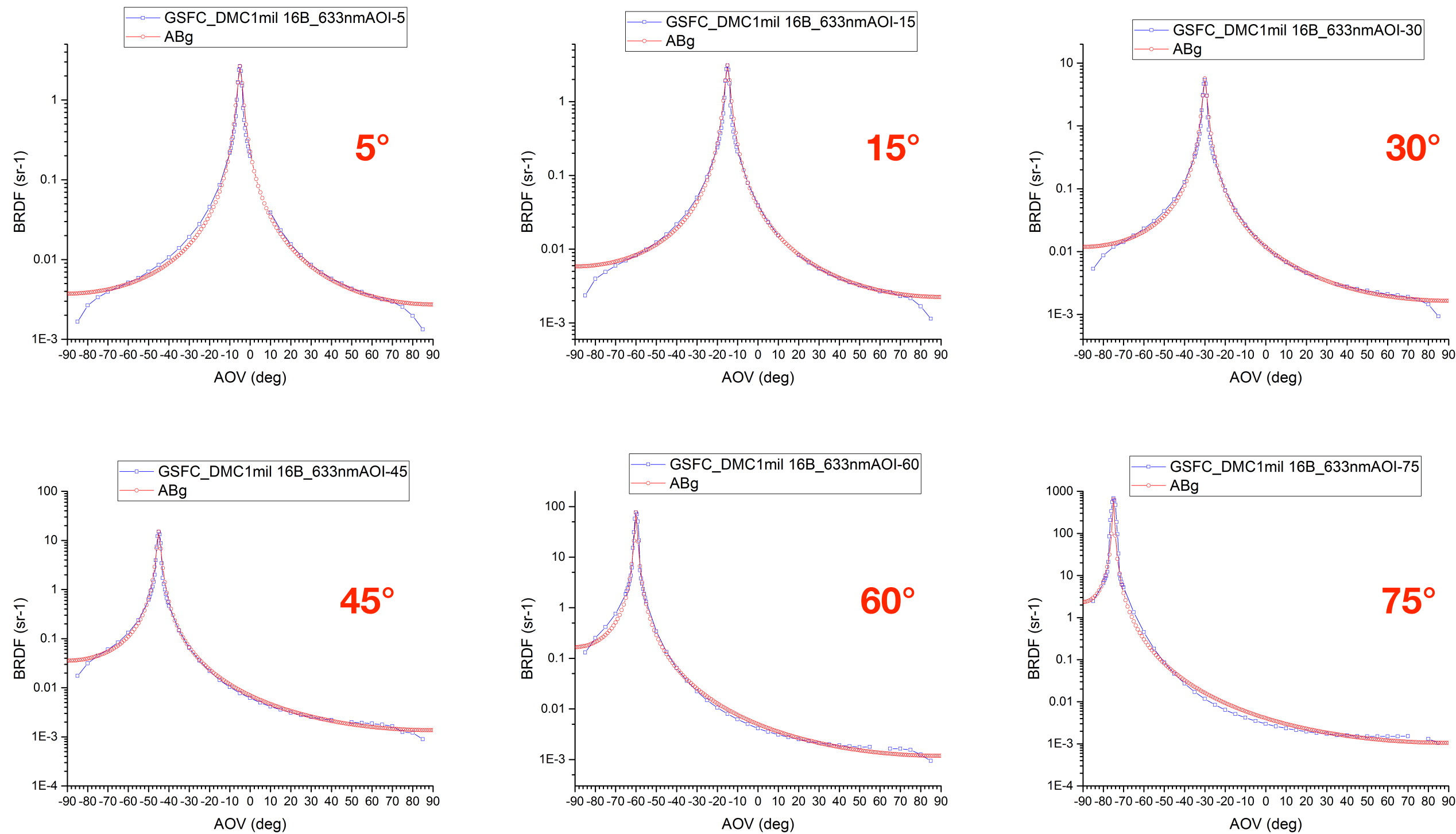




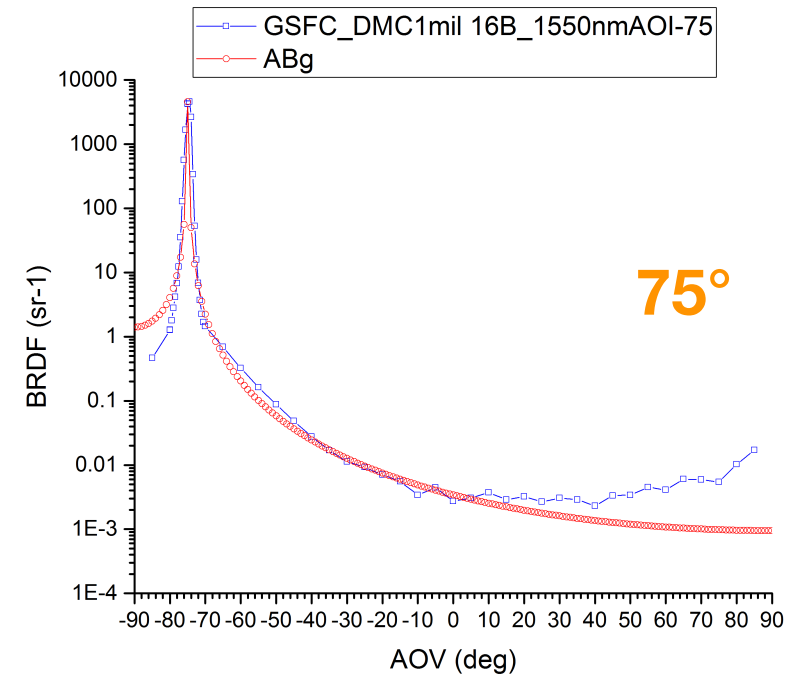
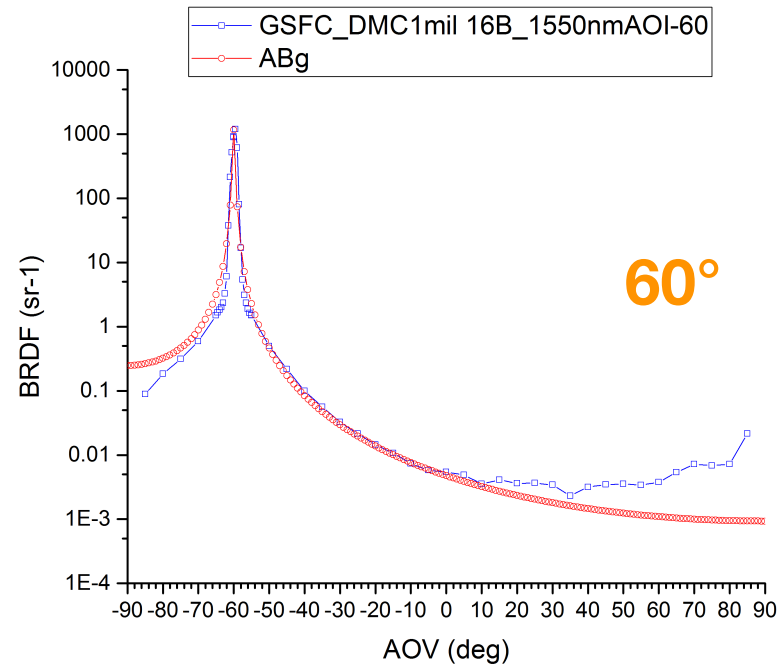
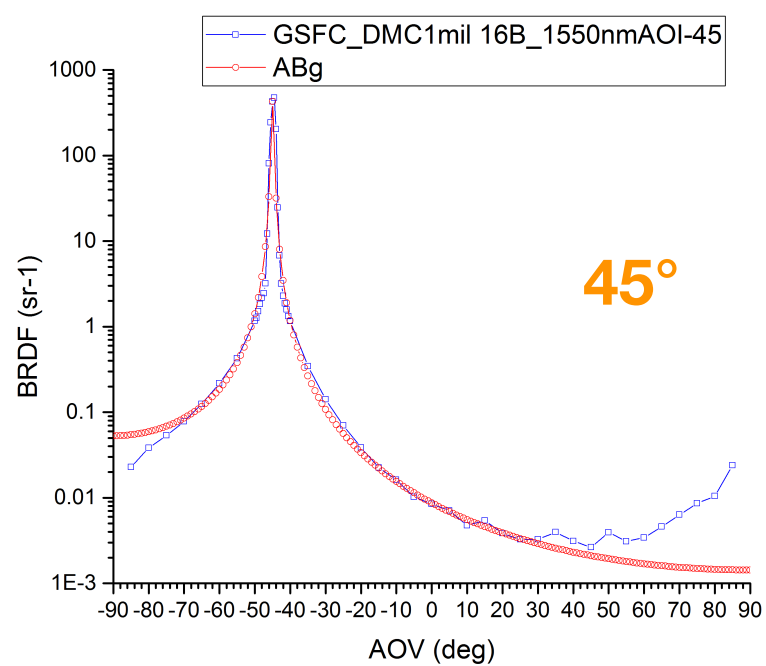
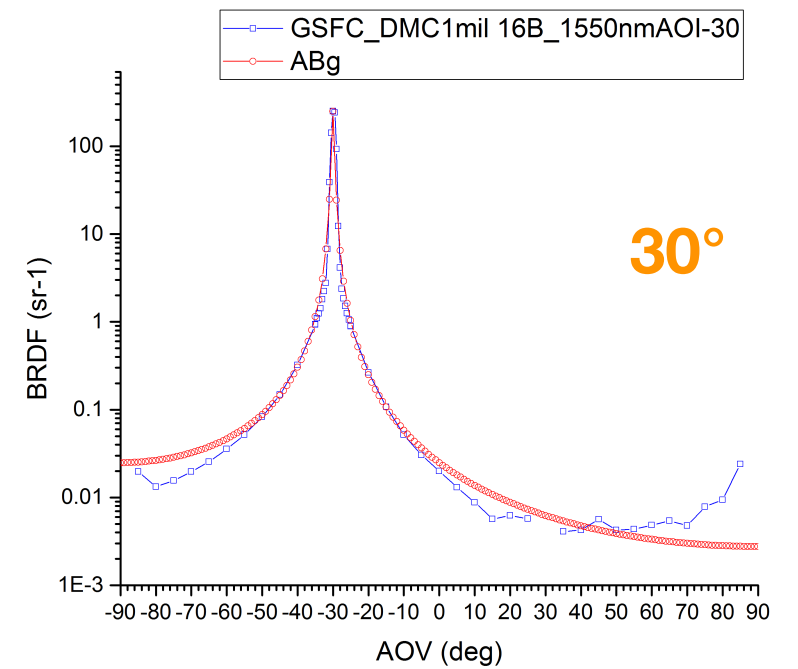
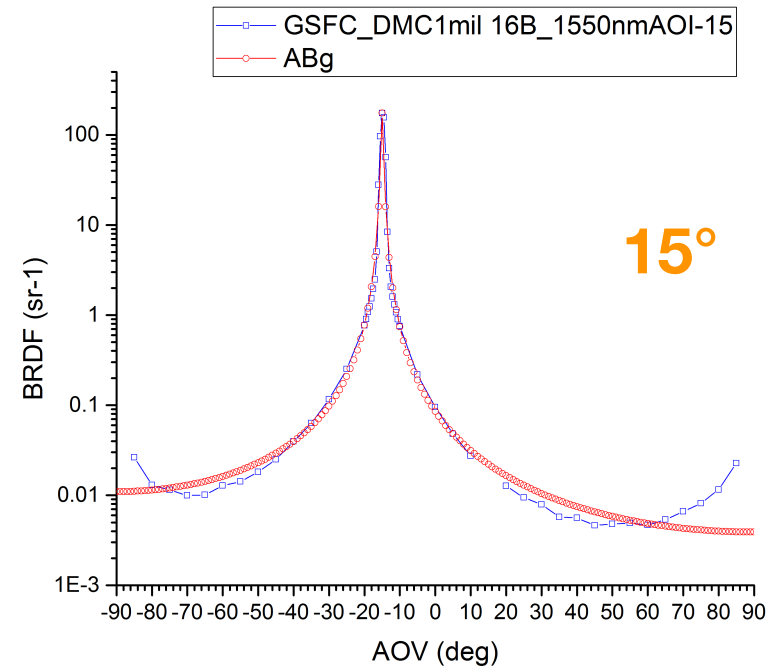
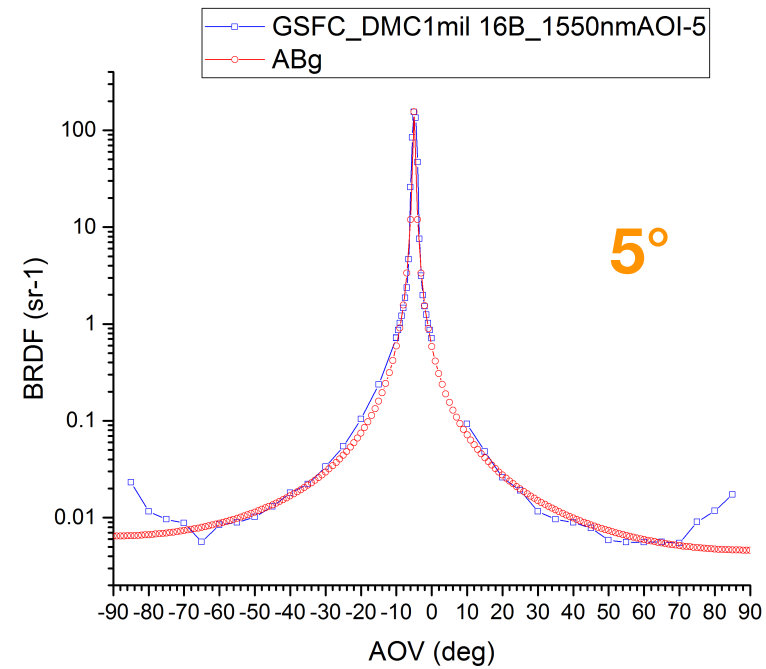
# RestoreL MLI BRDF data and direct ABg model fitting



# 633 nm BRDF results of GSFC DMC 1 mil at AOIs of 5, 15, 30, 45, 60, 75° and direct ABg model fittings



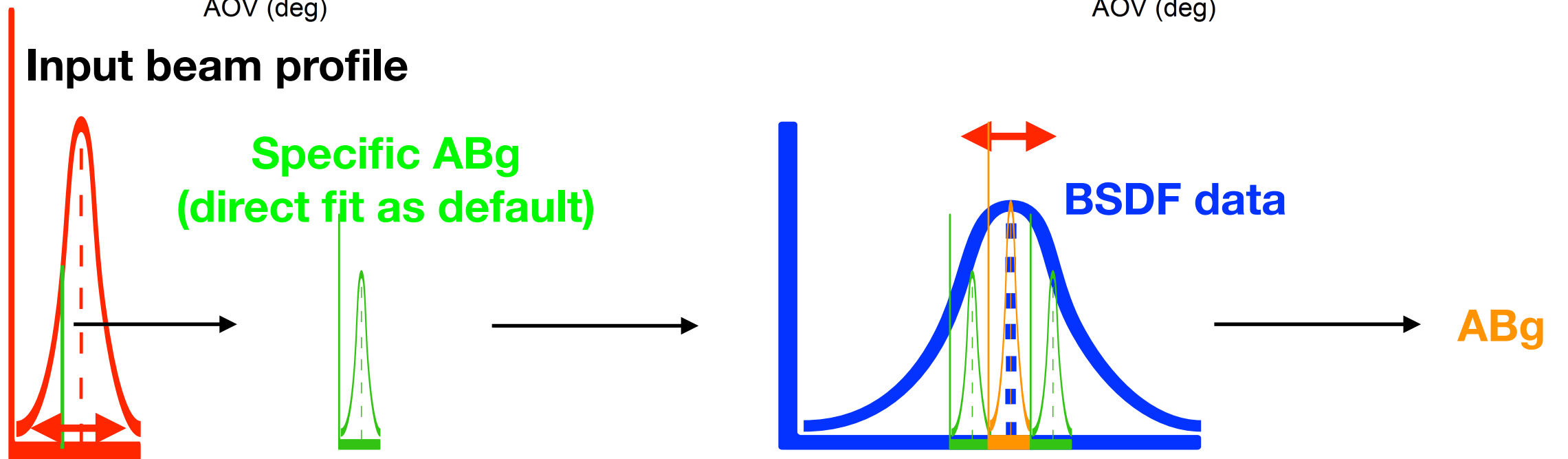
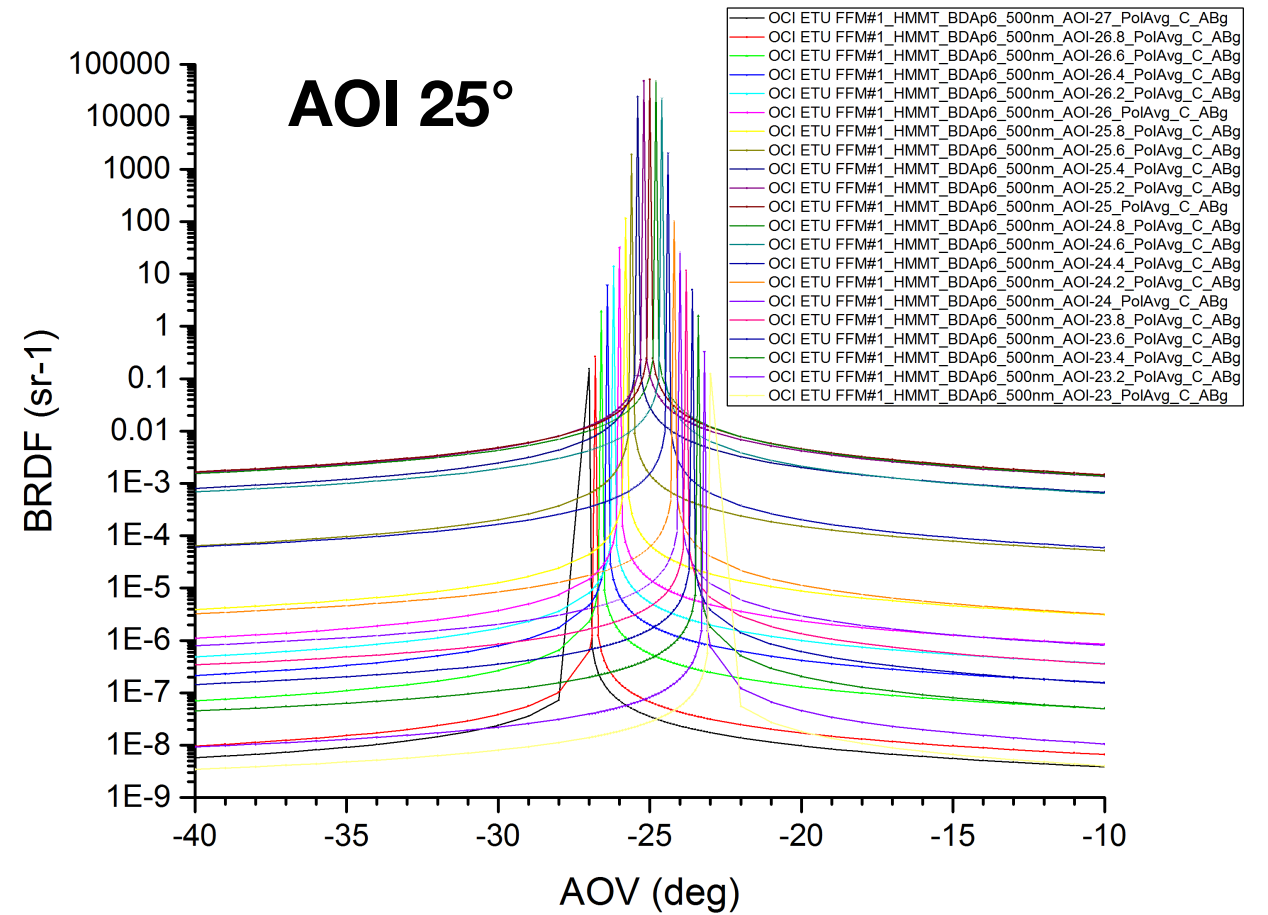
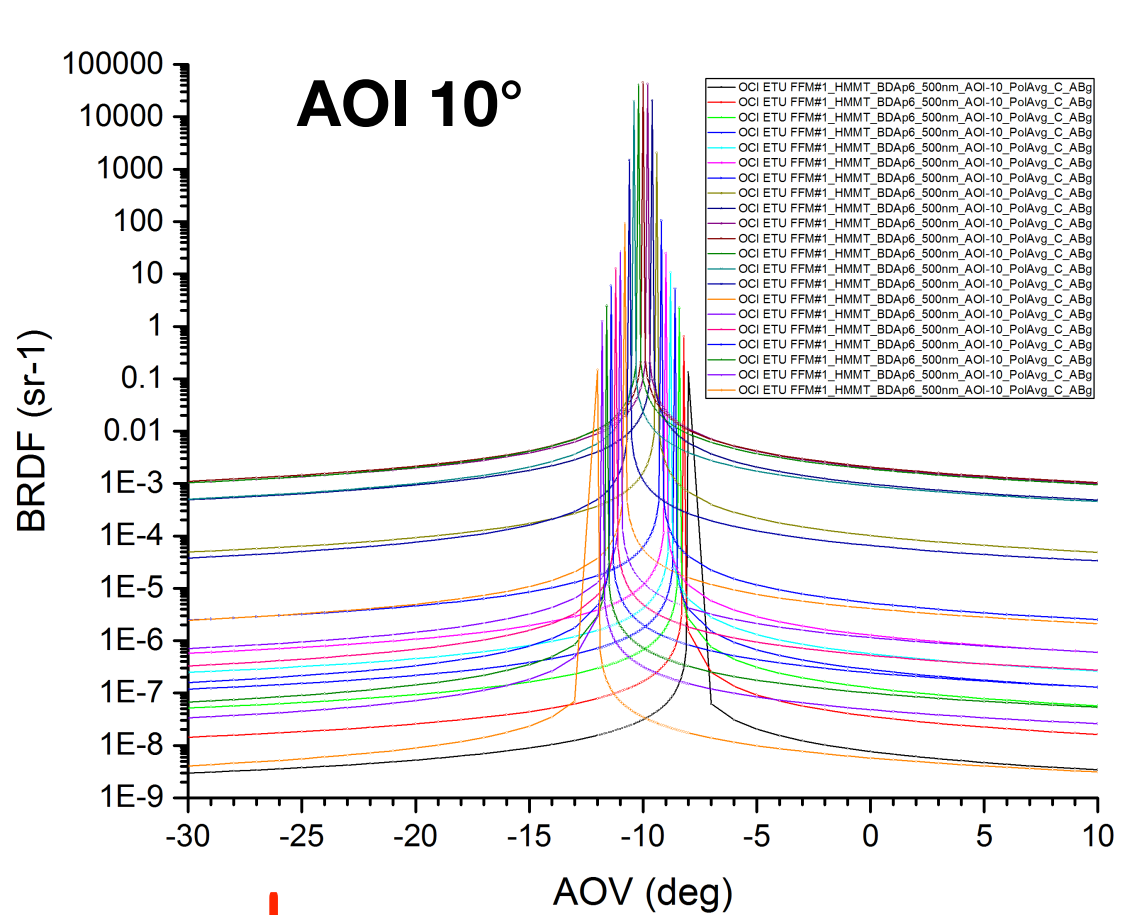
# 1550 nm BRDF results of GSFC DMC 1 mil at AOIs of 5, 15, 30, 45, 60, 75° and direct ABg model fitting



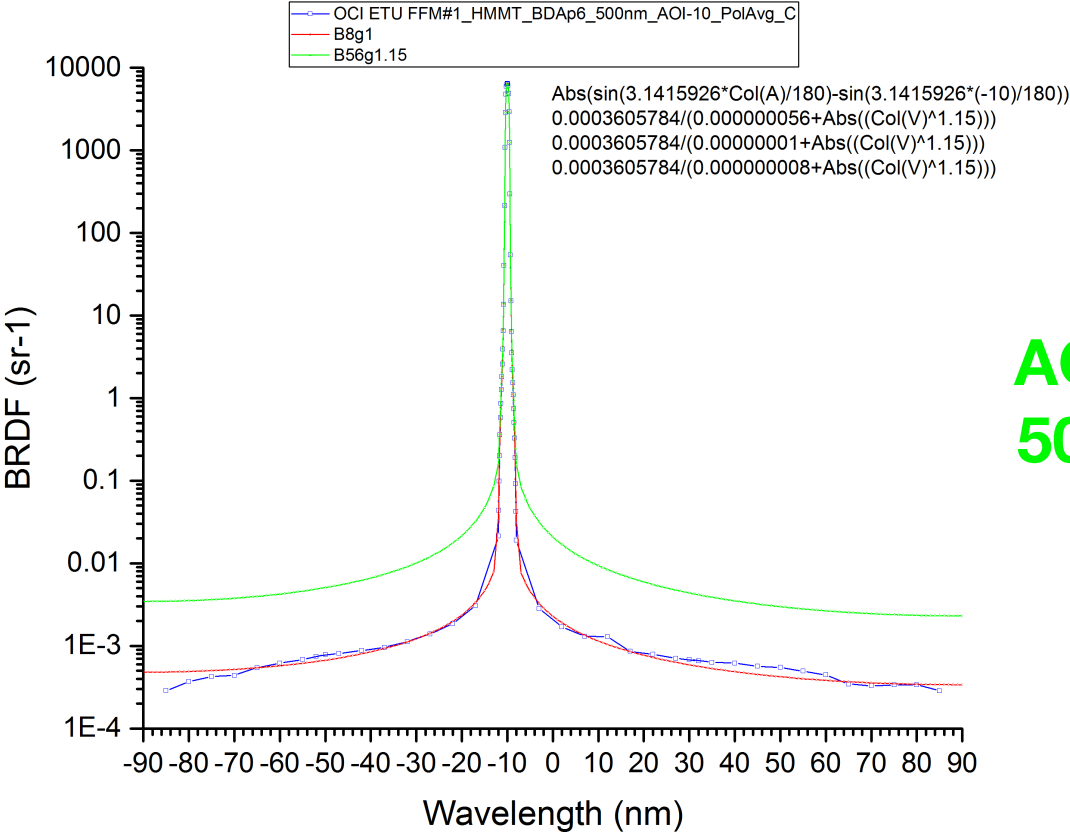


## **2. Determination of ABg parameters using deconvolution**

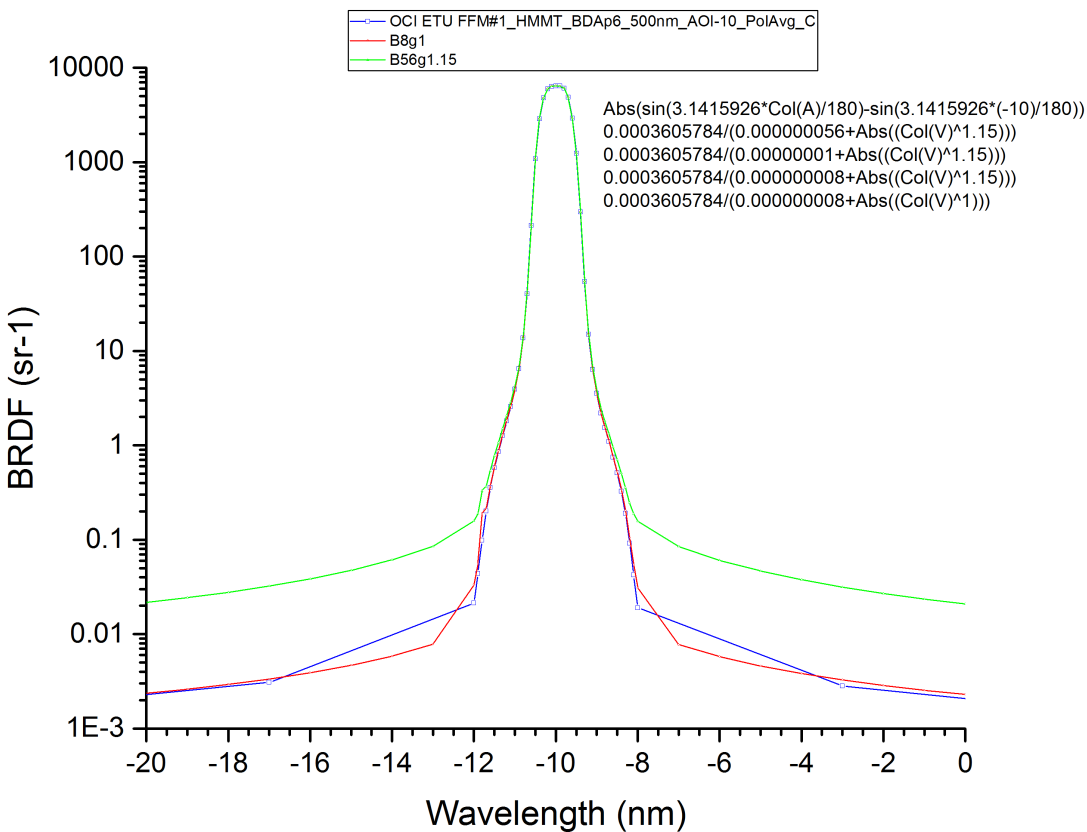
# ABg model fitting of BSDF data at 500 nm from OCI flat mirror with deconvolution



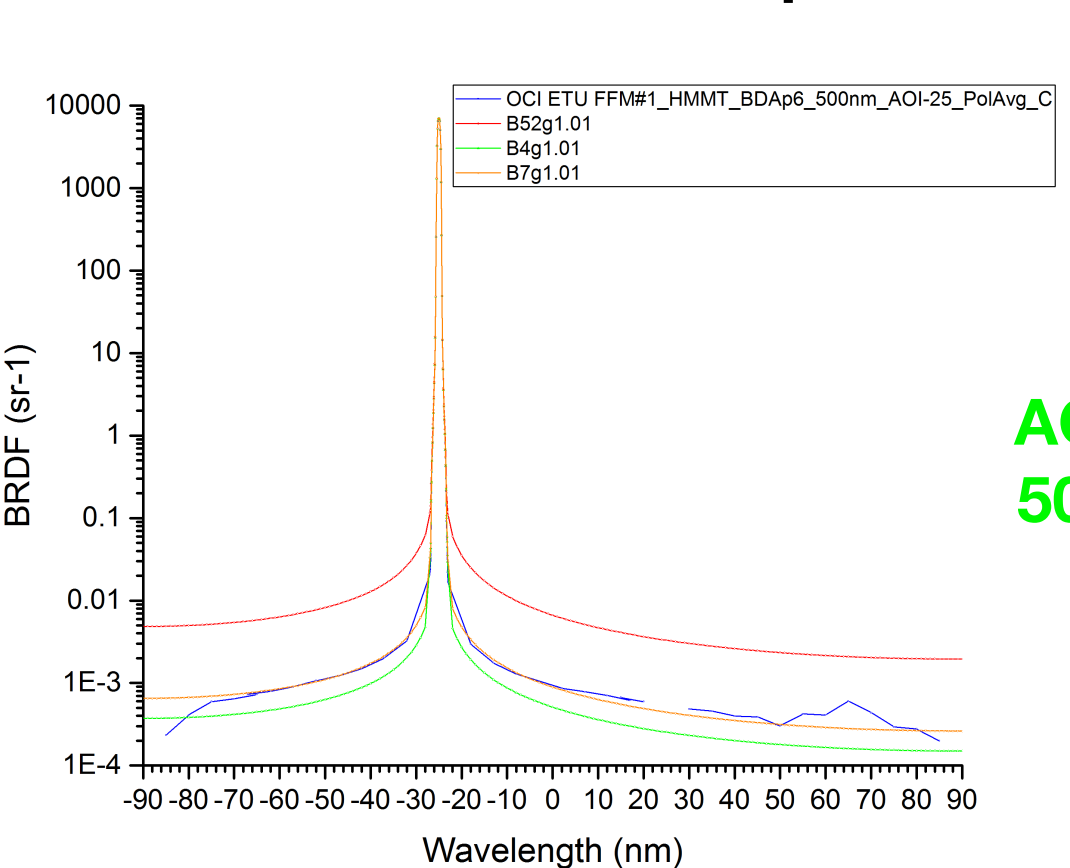
# Comparison of OCI Flat mirror BSDF ABg fittings w/wo deconvolution



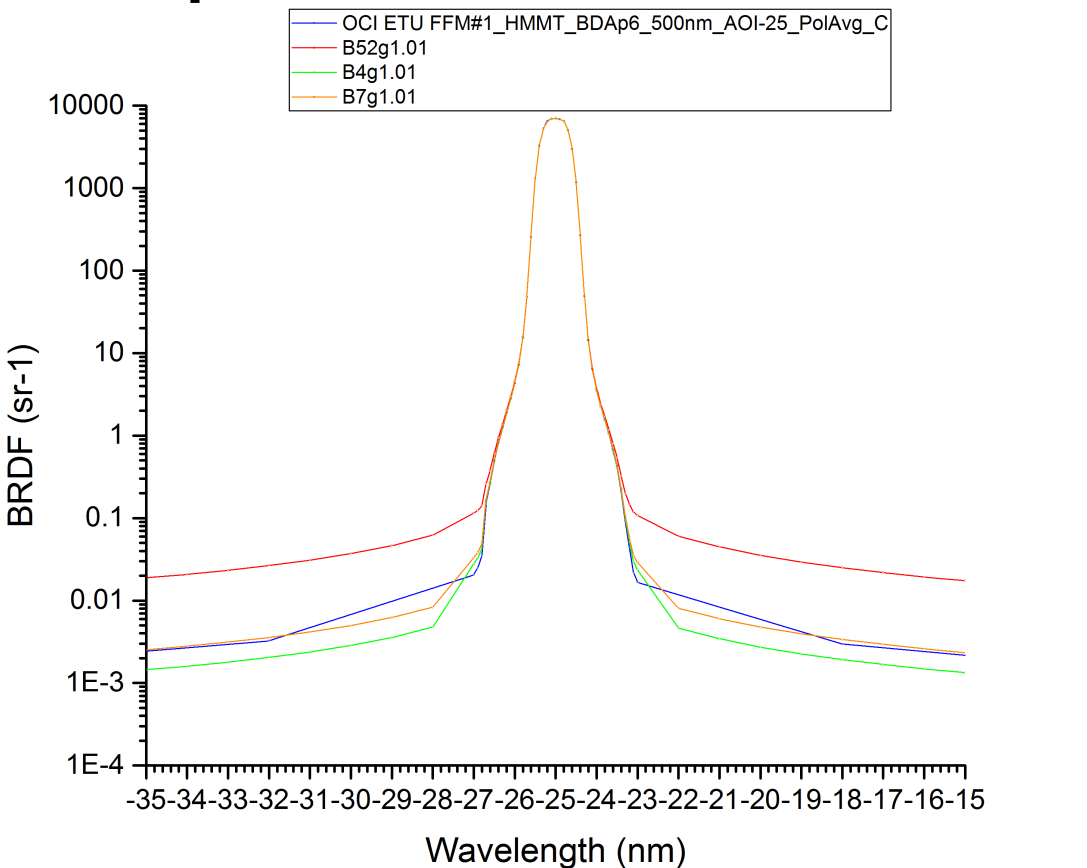
AOI 10°  
500 nm



Case I Small surface optical figure  
Input beam = Reflected peak

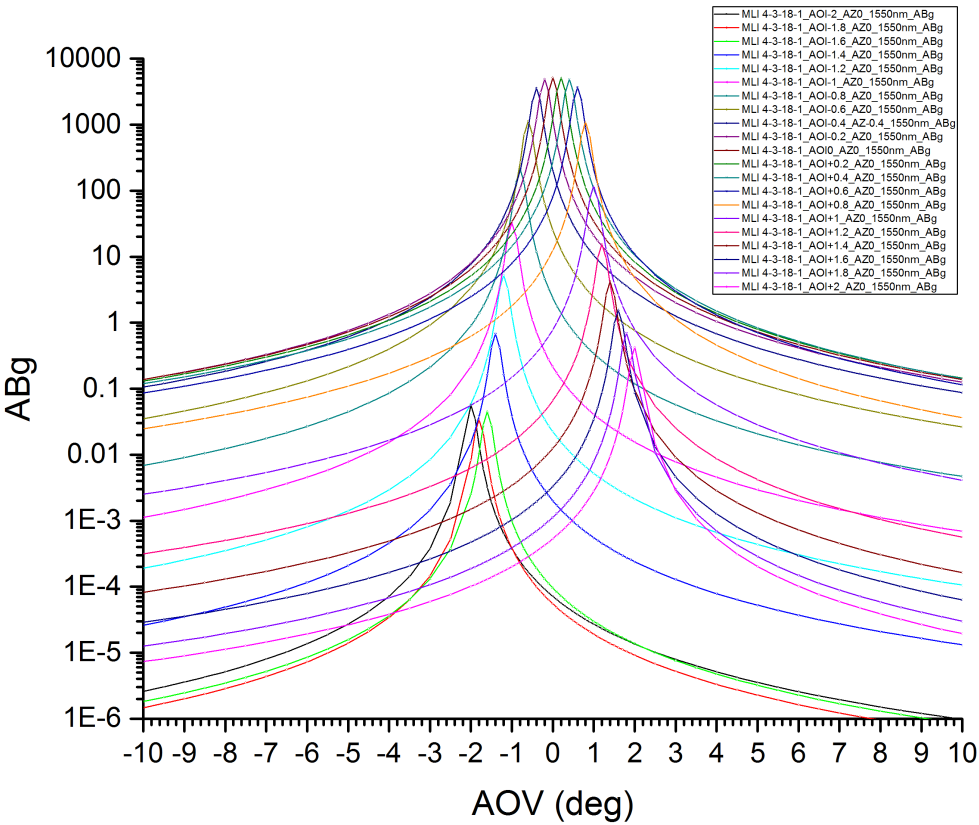
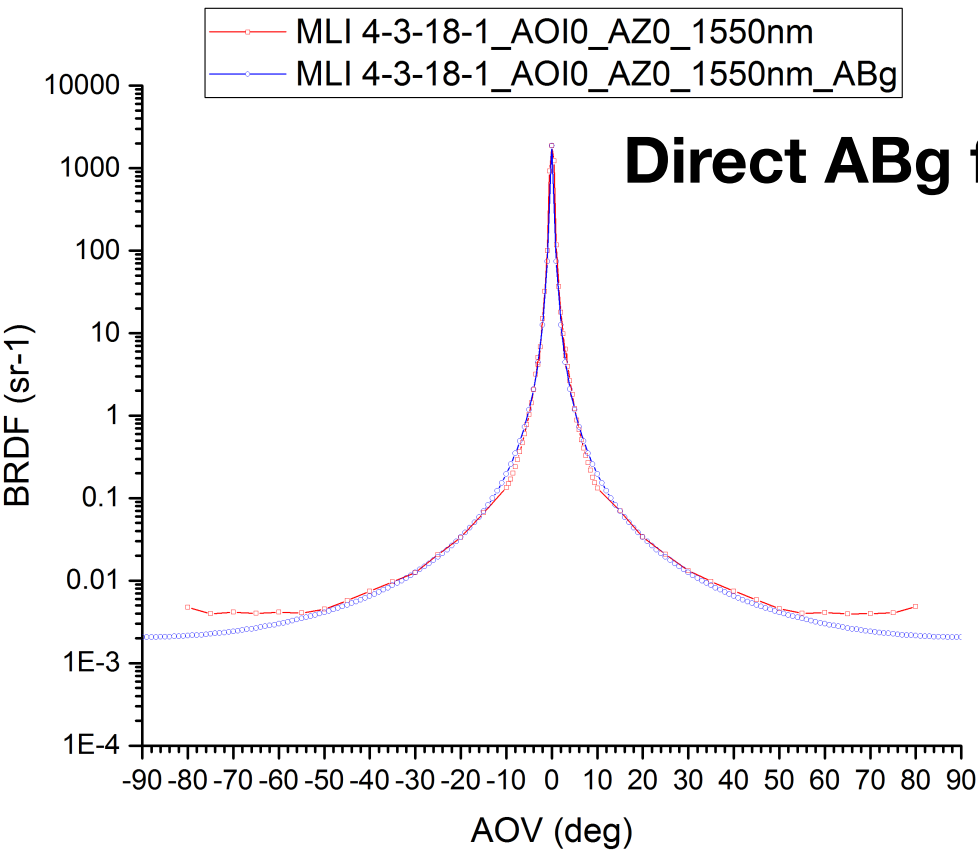


AOI 25°  
500 nm

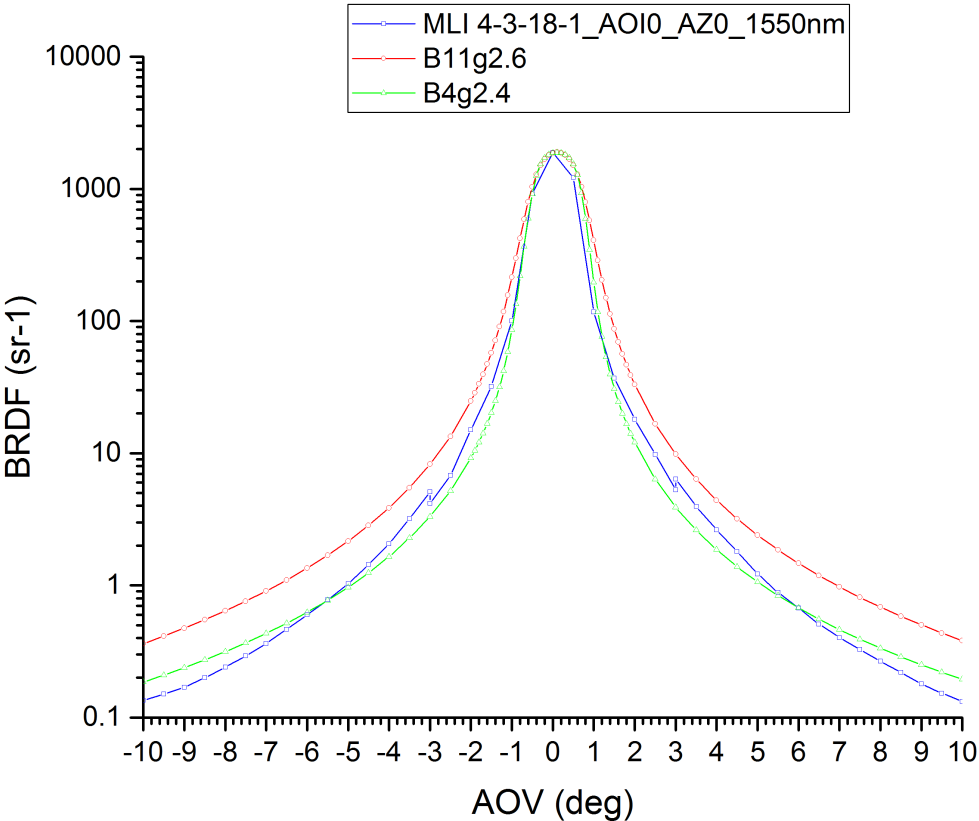
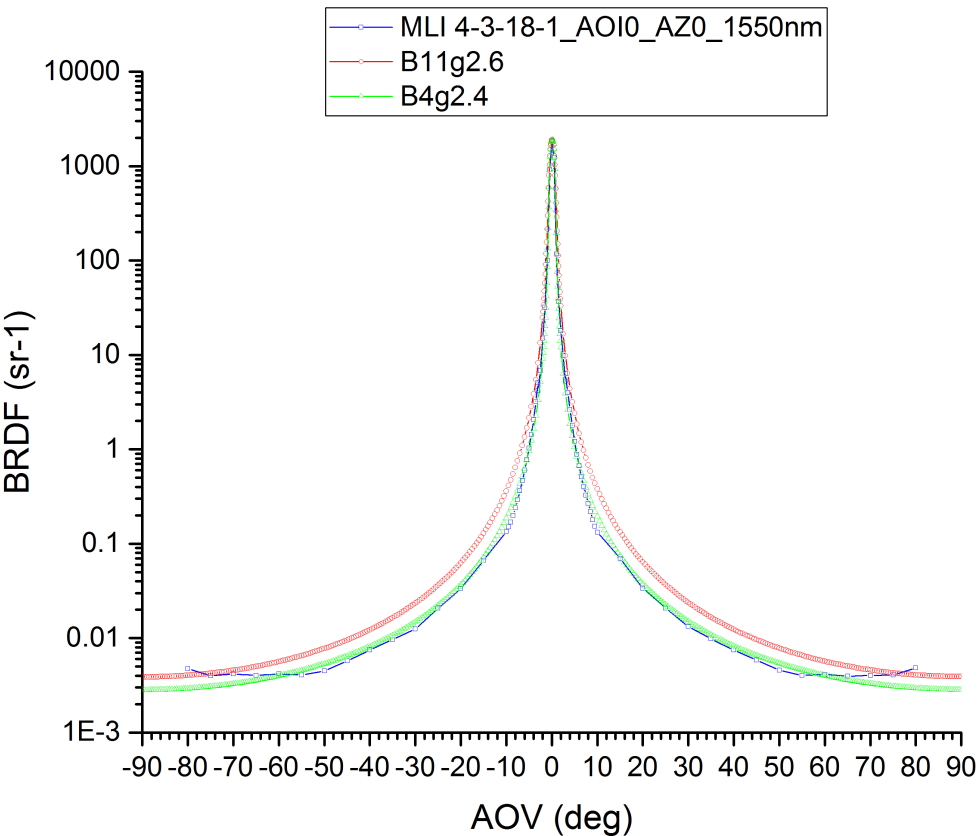




# Comparison of MLI BSDF ABg fittings w/wo deconvolution



**AOI 0°  
1550 nm**



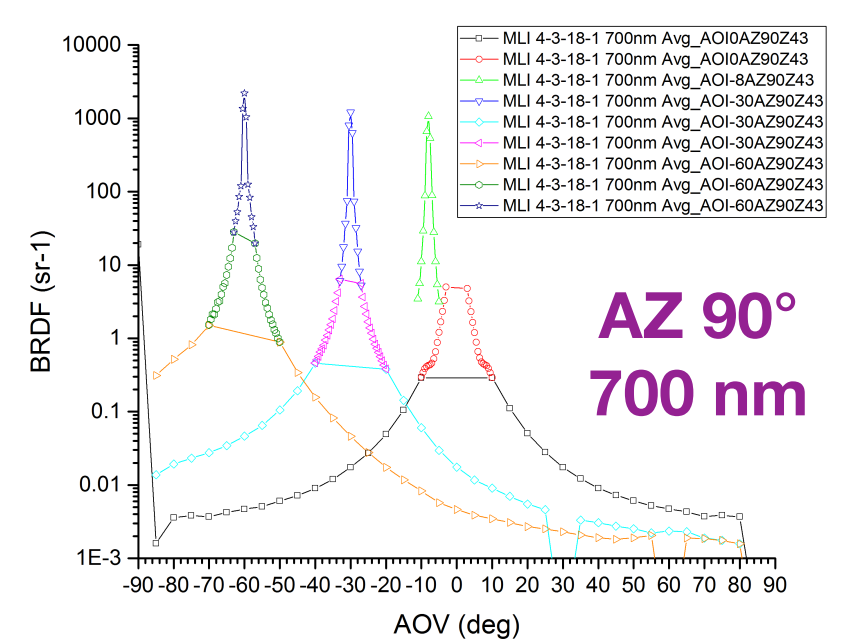
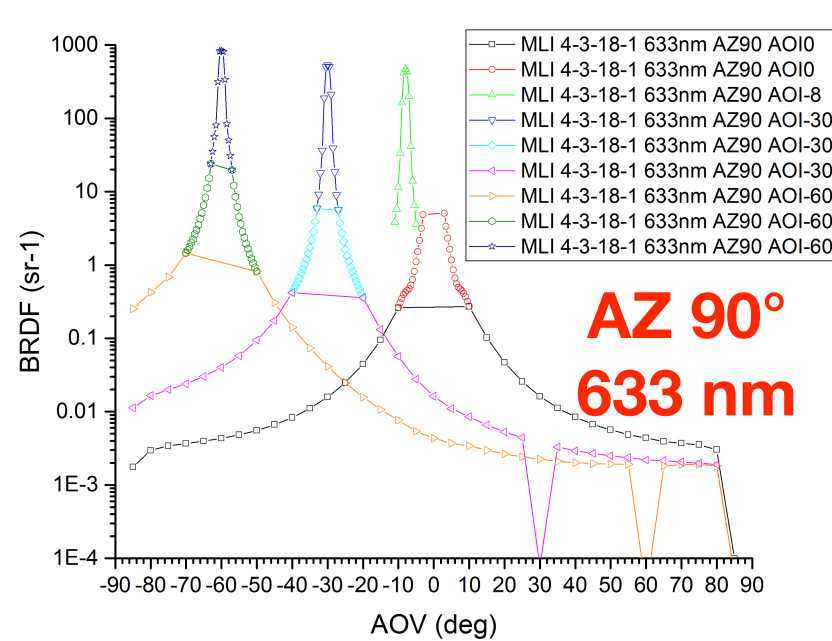
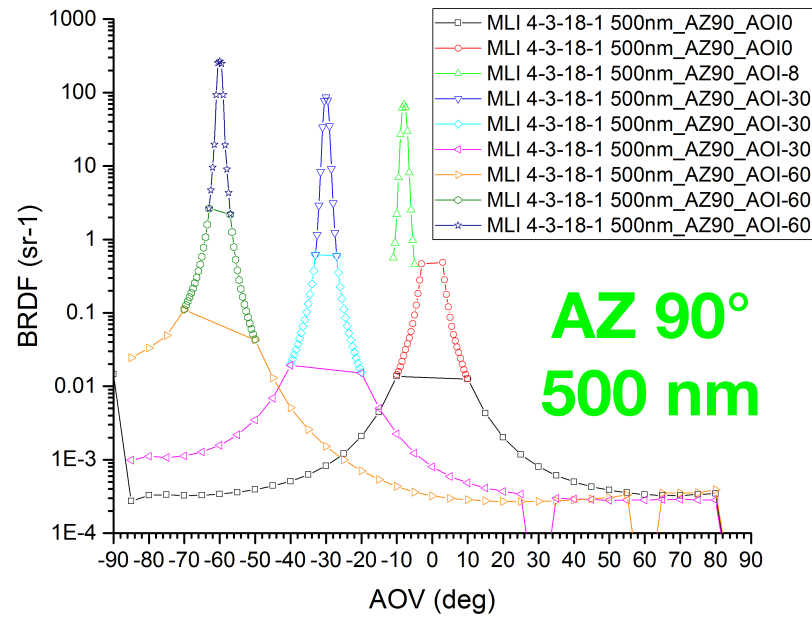
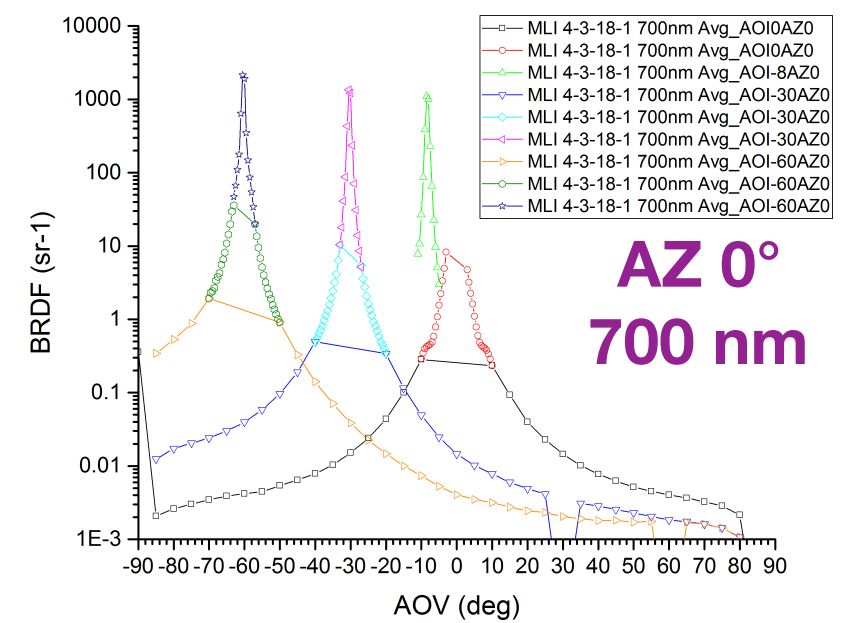
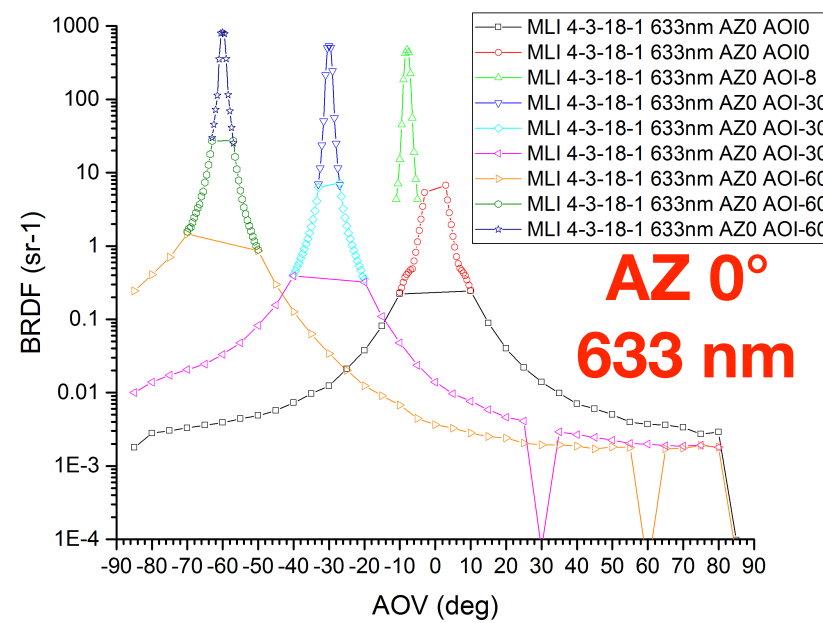
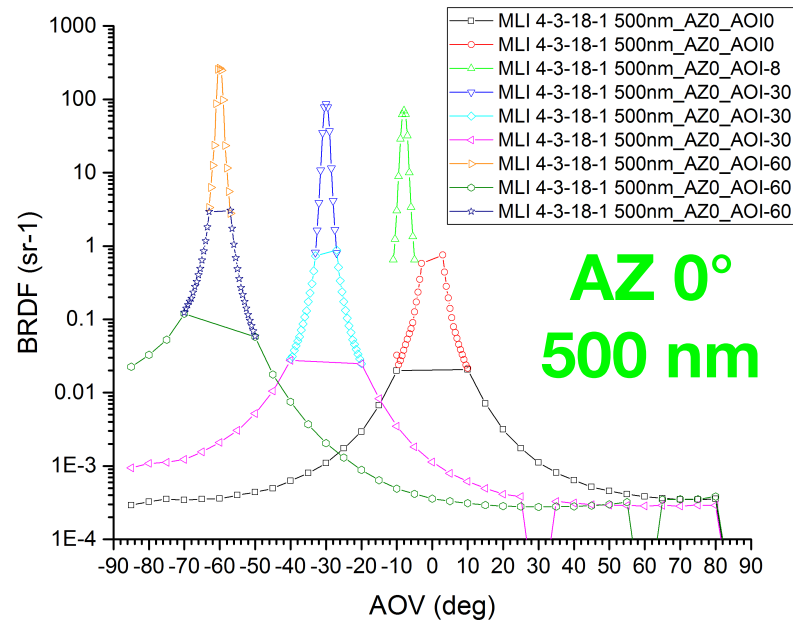
# Summary

- **New BRDF measurement capability for specular/polished surface using TTG**
- **Instrument signature, huge dynamic ranges of signal level, flexible setups for flat/curved mirrors**
- **Determination of ABg parameters by taking into account of deconvolution of light beam profile and detector aperture for two specific cases**

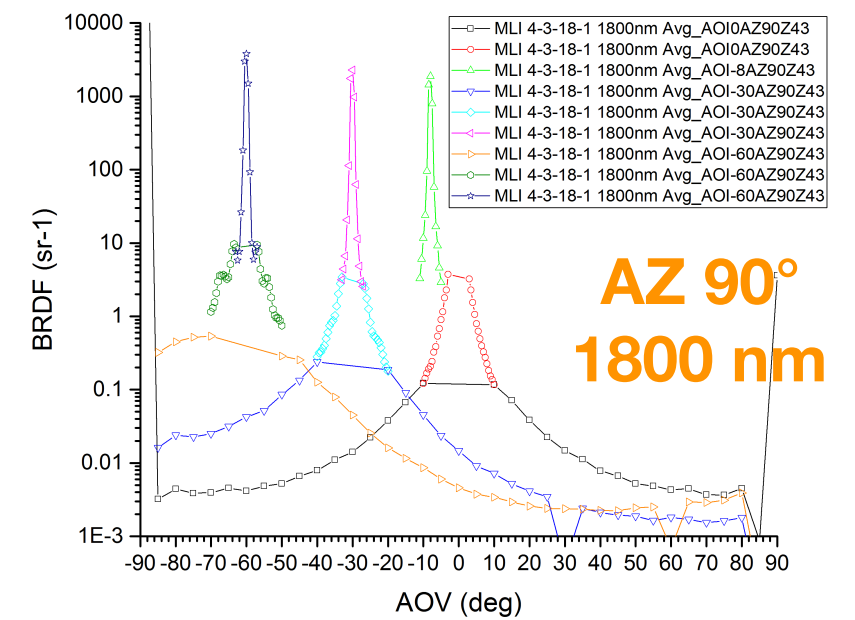
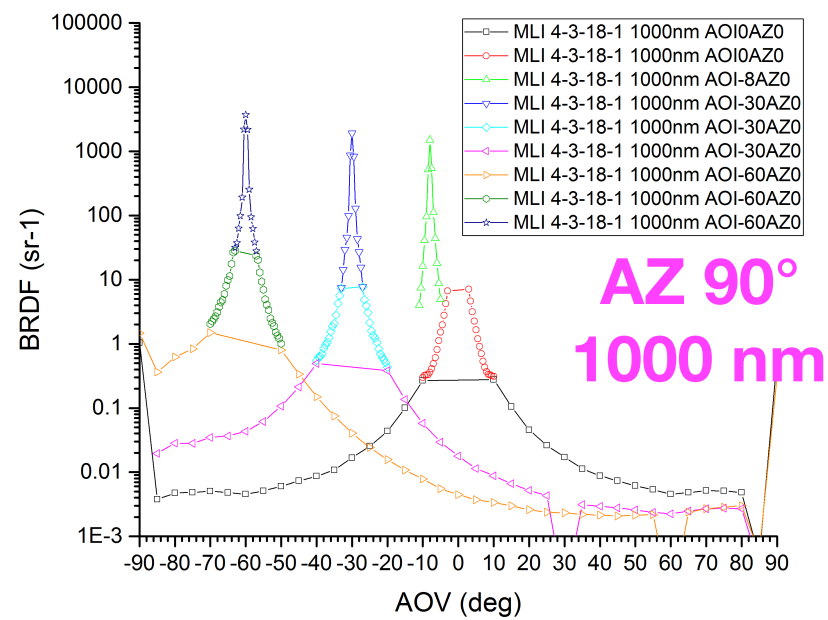
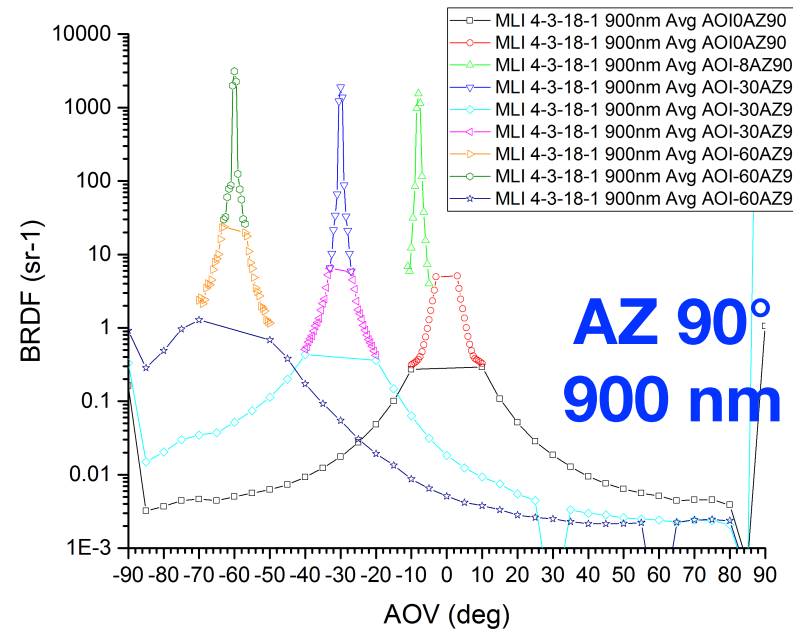
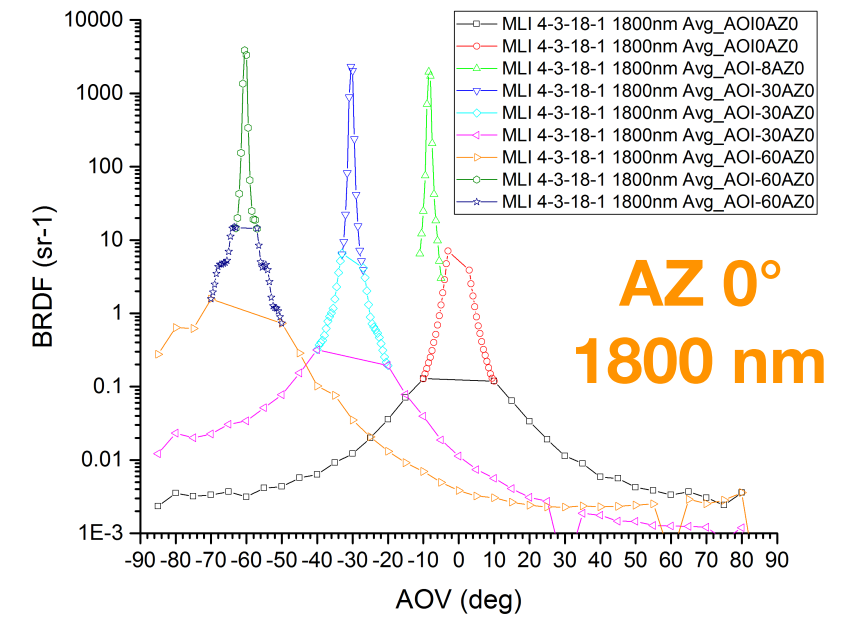
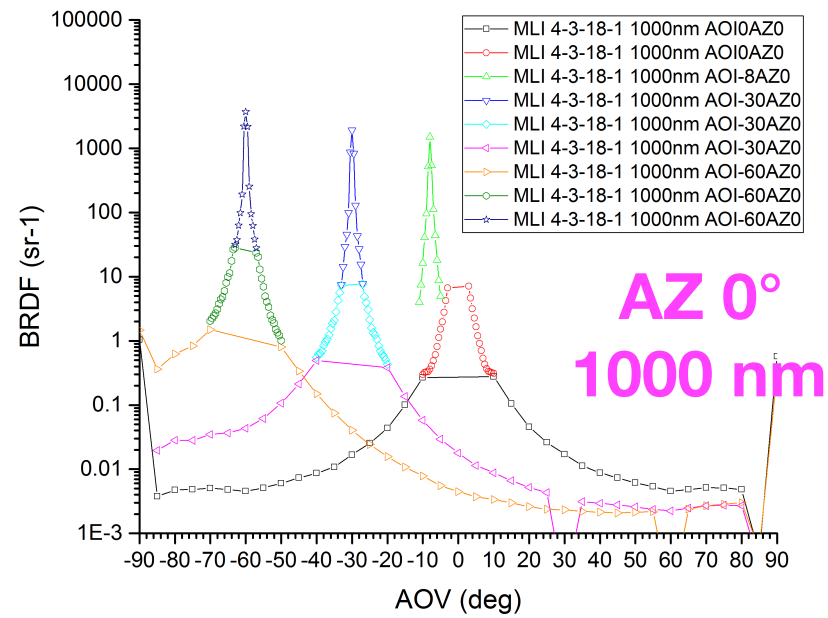
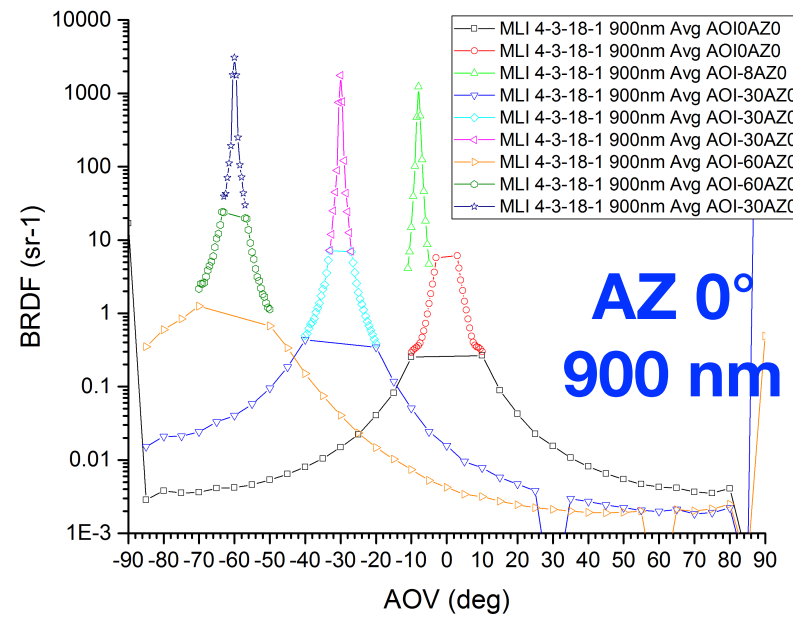
## **In the future**

- **Establishment of BSDF scale for specular/polished surface materials**
- **Validation of extracted ABg parameters using other methods**
- **Determination of roughness parameters for smooth surface (microroughness)**
- **Prediction of stray light performance of an optical system**

# RestoreL MLI BSDF at 500, 633 and 700 nm with AOI 0, 8, 30, 60°

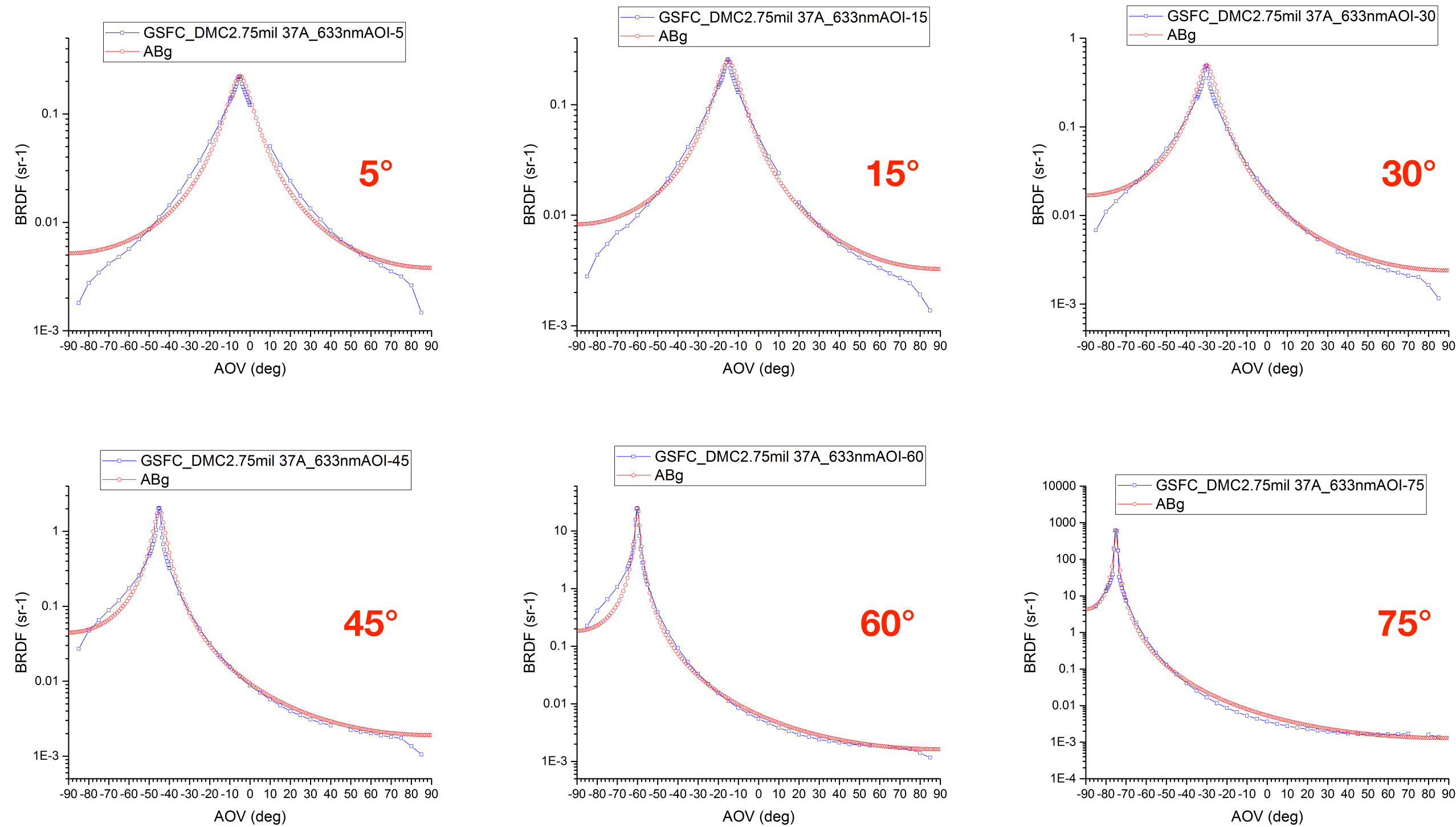


# RestoreL MLI BSDF at 900, 1000 and 1800 nm with AOI 0, 8, 30, 60°





# 633 nm BRDF results of GSFC DMC 2.75 mil at AOIs of 5, 15, 30, 45 60, 75° and direct ABg model fitting



# 1550 nm BRDF results of GSFC DMC 2.75 mil at AOIs of 5, 15, 30, 45, 60, 75° and direct ABg model fitting

